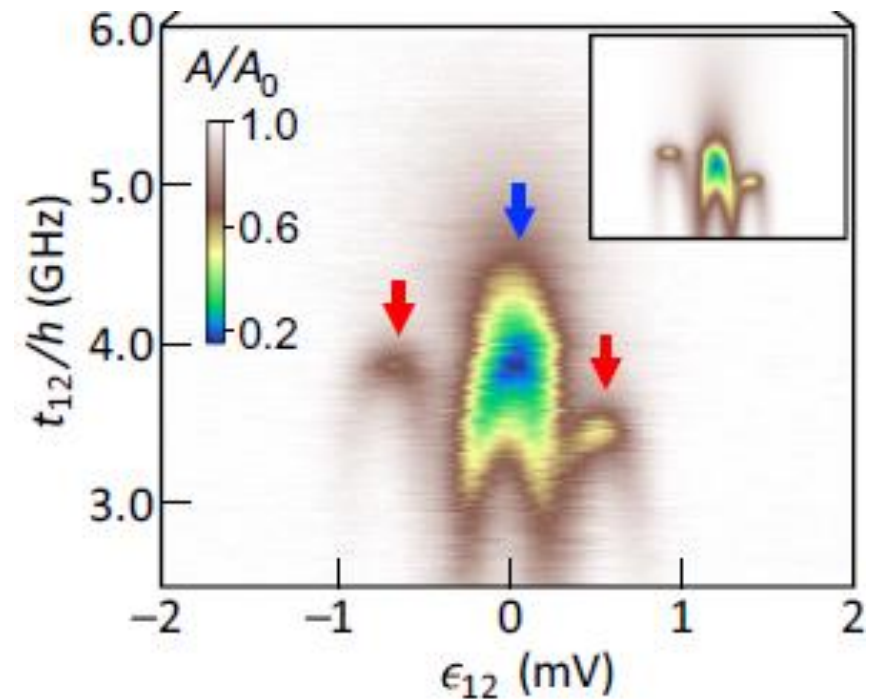
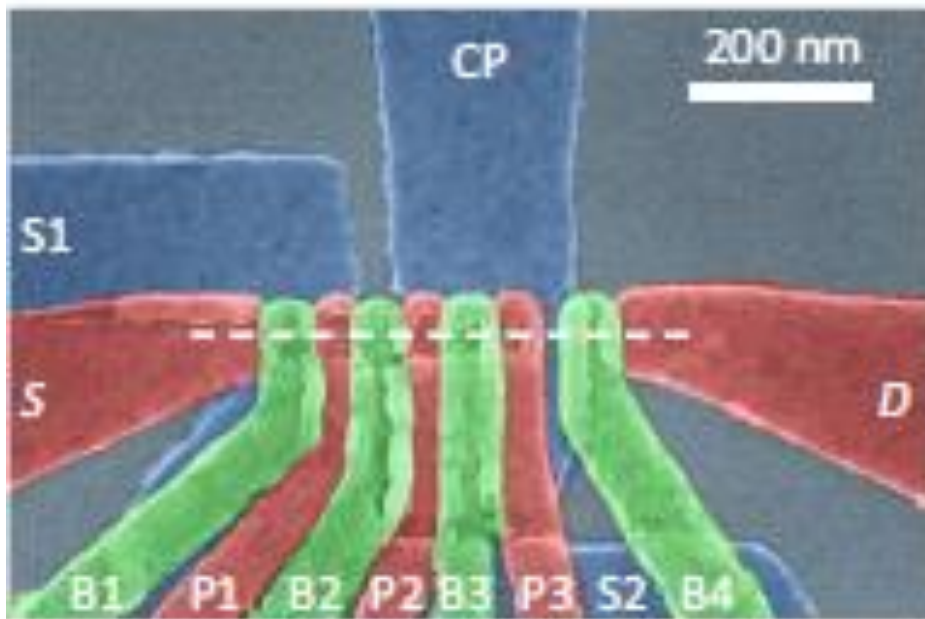


Probing the Variation of the Intervalley Tunnel Coupling in a Silicon Triple Quantum Dot

F. Borjans, X. Zhang, X. Mi, G. Cheng, N. Yao, C.A.C. Jackson, L.F. Edge and J.R. Petta (PRX Quantum 2, 2021)

Journal Club of the NCCR spin on May 16 2022

JH Ungerer



Motivation

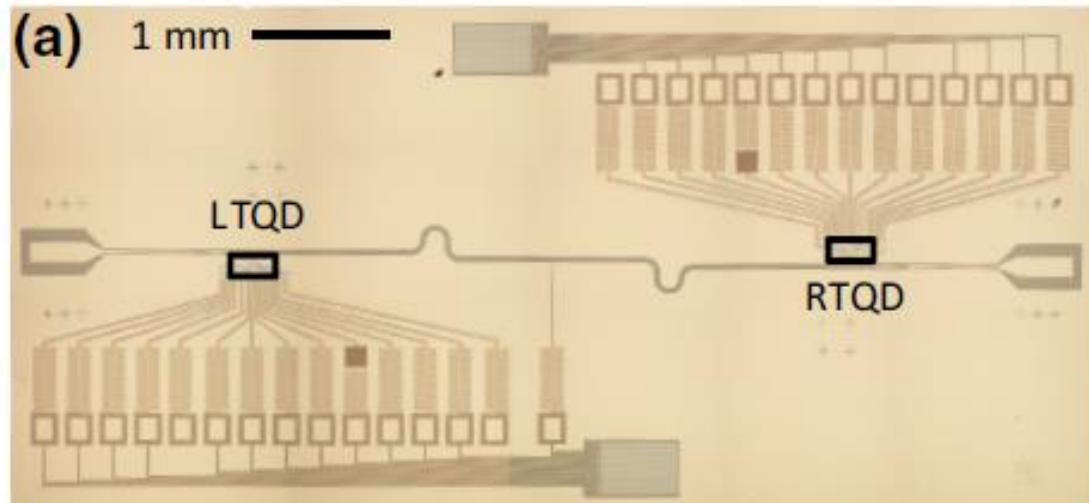
- **Valley degree of freedom of electrons in Silicon**
 - Valley-orbit coupling can limit spin lifetime and inhibit coherent electron shuffling

Motivation

- **Valley degree of freedom of electrons in Silicon**
 - Valley-orbit coupling can limit spin lifetime and inhibit coherent electron shuffling
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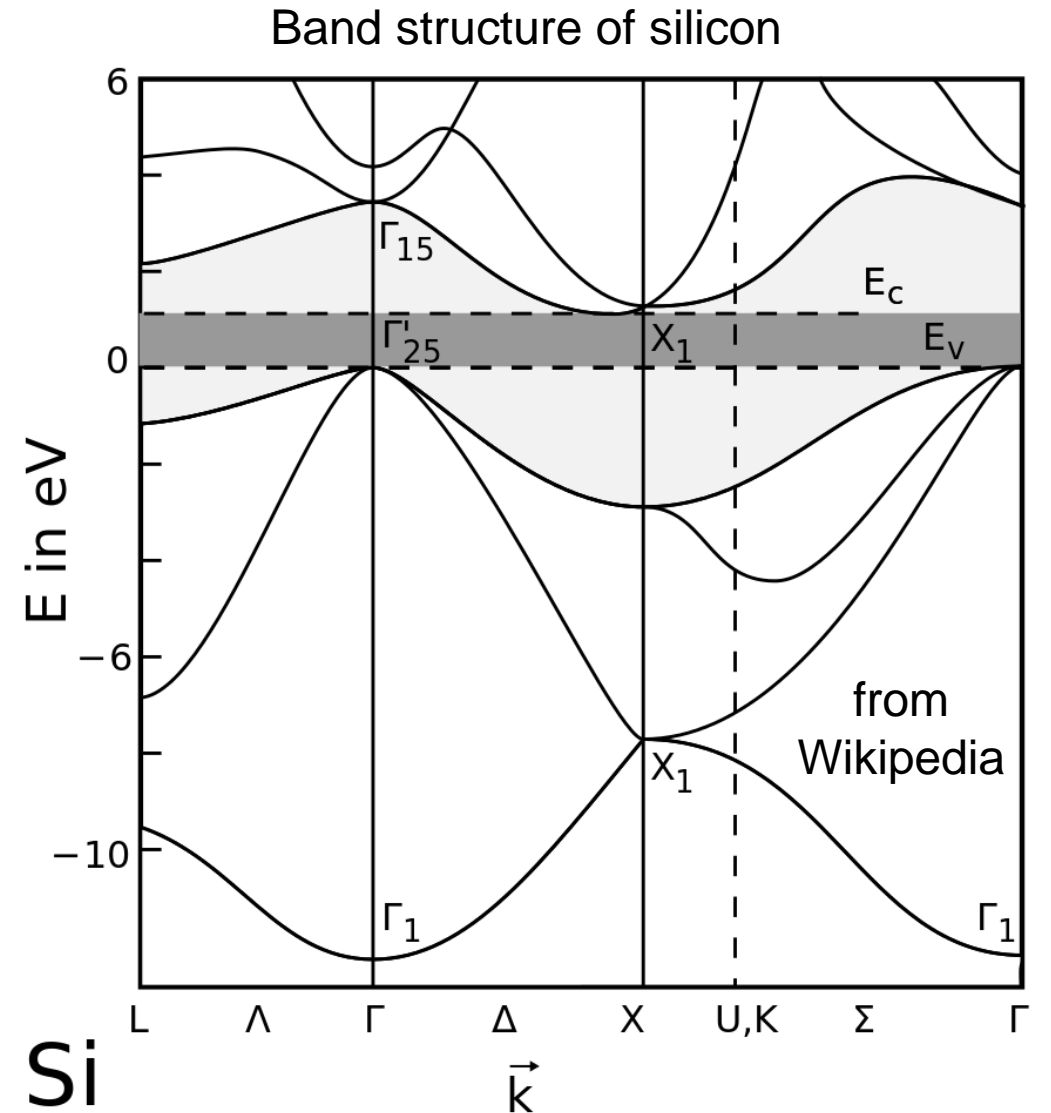
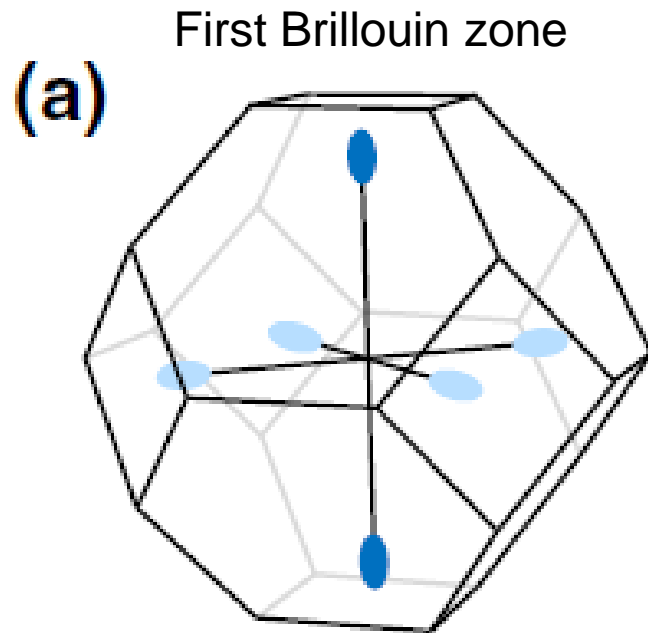
Motivation

- **Valley degree of freedom of electrons in Silicon**
 - Valley-orbit coupling can limit spin lifetime and inhibit coherent electron shuffling
 - Measuring the valley splitting gives insights into the quality of the crystal growth
- **Circuit QED for determining valley splitting**
 - Resonator sensitive to avoided crossings due to intra- and inter valley tunneling



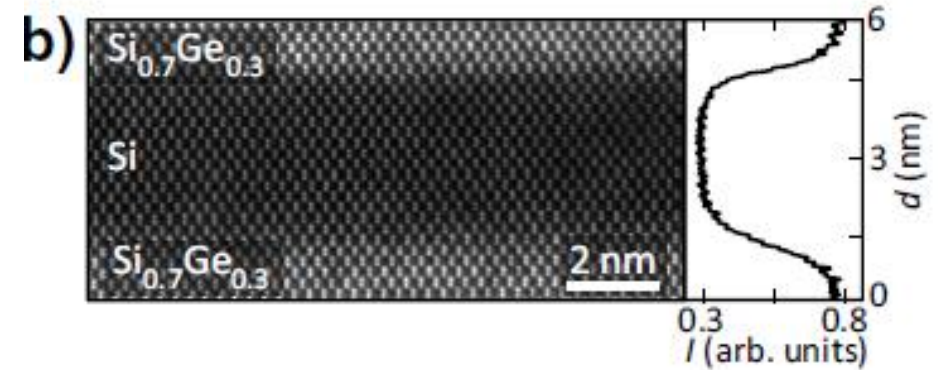
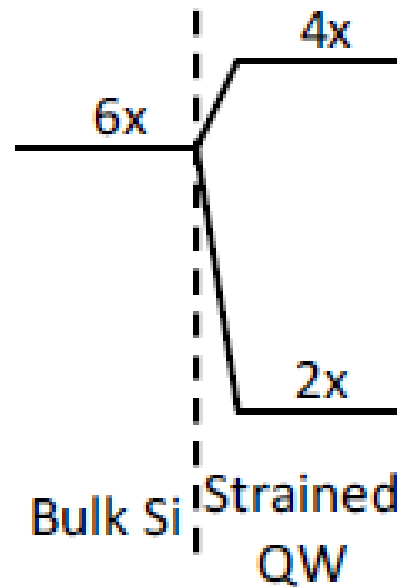
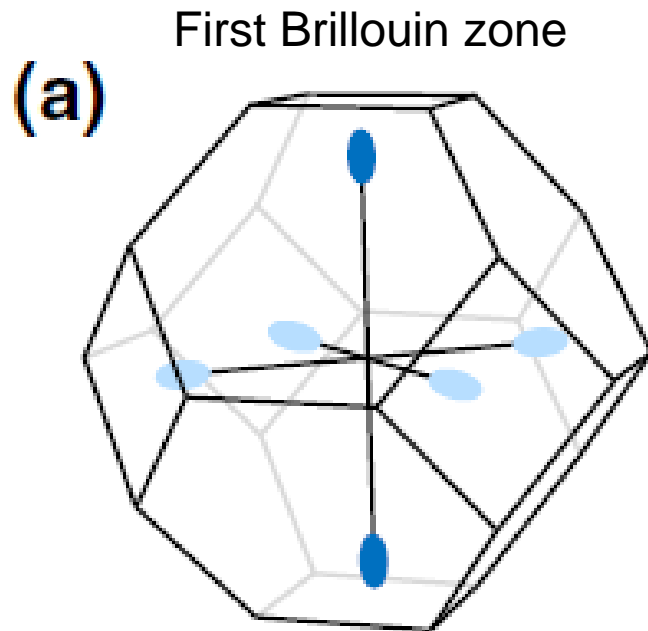
Valley degree of freedom in silicon quantum dots

- Diamond cubic crystal structure
- Six degenerate CB minima (valleys)



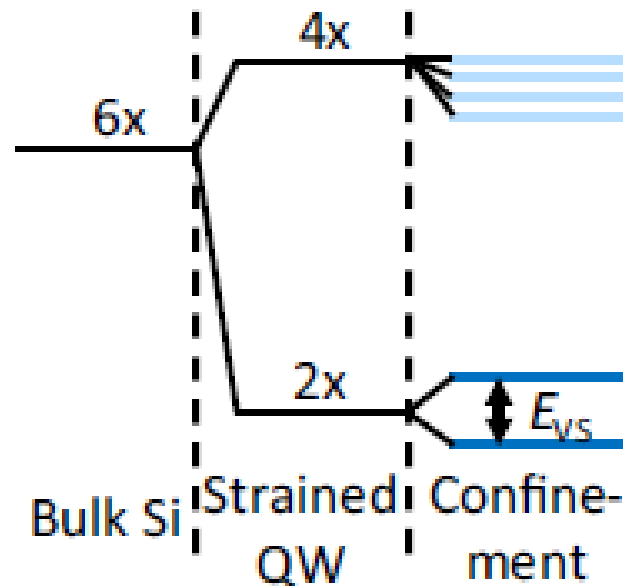
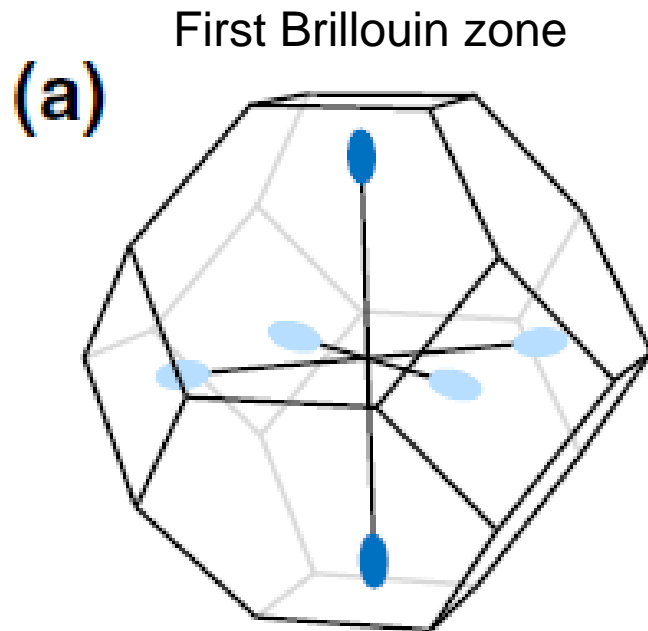
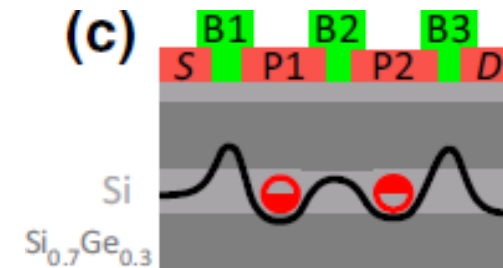
Valley degree of freedom in silicon quantum dots

- **Tensile strain of quantum well**
 - Increased energy of $\pm X, \pm Y$ valleys



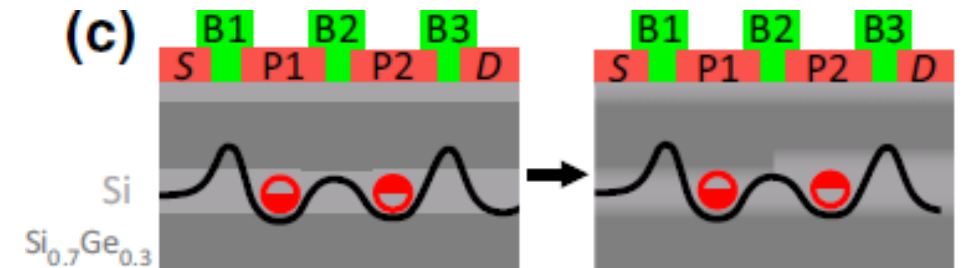
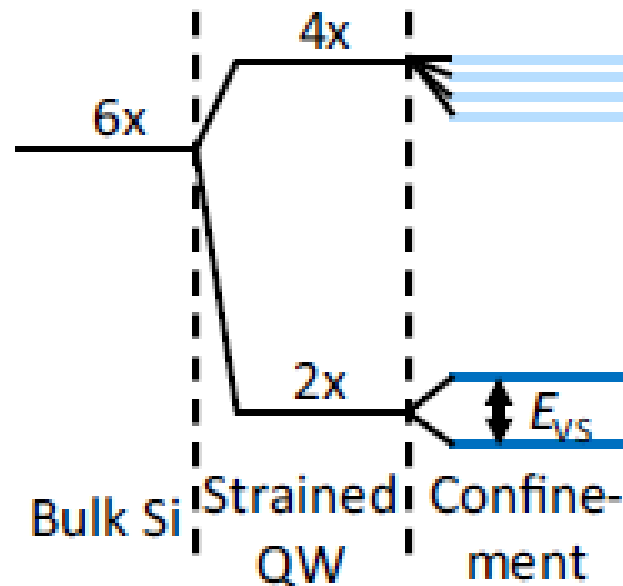
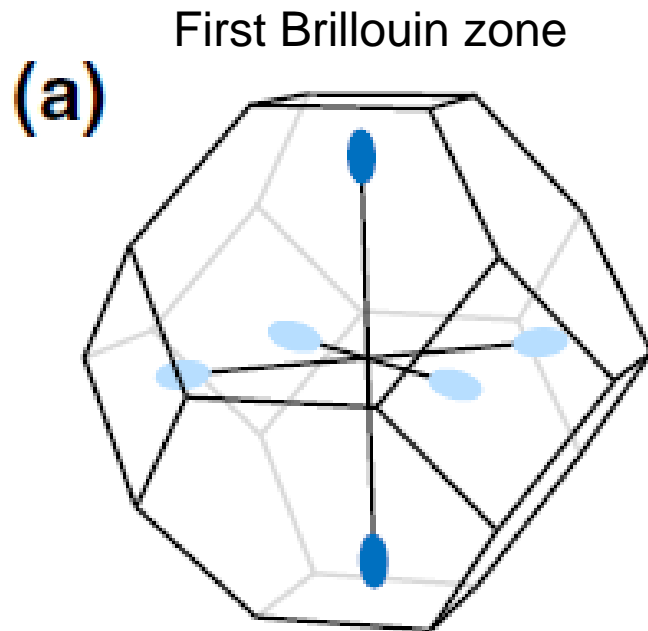
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- **Break of inversion symmetry (confinement)**
 - Lifted degeneracy of $\pm Z$



Valley degree of freedom in silicon quantum dots

- **Tensile strain of quantum well**
 - Increased energy of $\pm X, \pm Y$ valleys
- **Break of inversion symmetry (confinement)**
 - Lifted degeneracy of $\pm Z$
- **Imperfect, soft interfaces and step edges**
 - Inter-valley tunneling



Valley degree of freedom in silicon quantum dots

- **Hamiltonian of 1-dot subsystem**

$$H_{V,i} = \begin{pmatrix} 0 & \Delta_i \\ \Delta_i^* & 0 \end{pmatrix}$$

Basis:

$$\{|i, +z\rangle, |i, -z\rangle\}$$

$\Delta = |\Delta|e^{i\Phi}$ valley coupling

Valley degree of freedom in silicon quantum dots

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- **Hamiltonian of DQD**

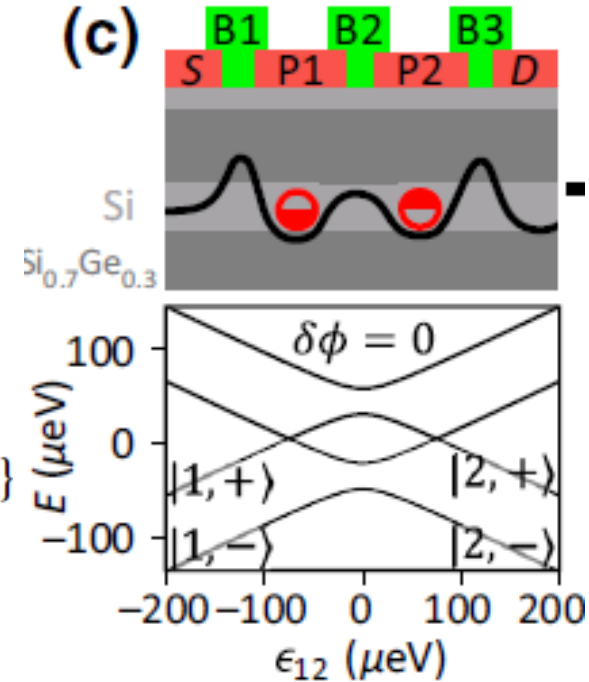
$$H_{ij}(\epsilon_{ij}) = \begin{pmatrix} \frac{\epsilon_{ij}}{2} & \Delta_i & t_c & 0 \\ \Delta_i^* & \frac{\epsilon_{ij}}{2} & 0 & t_c \\ t_c & 0 & -\frac{\epsilon_{ij}}{2} & \Delta_j \\ 0 & t_c & \Delta_j^* & -\frac{\epsilon_{ij}}{2} \end{pmatrix}$$

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t_c = dot-dot tunneling

ϵ = dot-dot detuning



Valley degree of freedom in silicon quantum dots

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- **After diagonalizing the single-dot part**

$$H'_{ij}(\epsilon_{ij}) = \begin{pmatrix} \frac{\epsilon_{ij}}{2} + E_{VS,i} & 0 & t_{ij} & t'_{ij} \\ 0 & \frac{\epsilon_{ij}}{2} & t'_{ij} & t_{ij} \\ t_{ij}^* & t'_{ij}^* & -\frac{\epsilon_{ij}}{2} + E_{VS,j} & 0 \\ t_{ij}^* & t'_{ij}^* & 0 & -\frac{\epsilon_{ij}}{2} \end{pmatrix}$$

Basis:

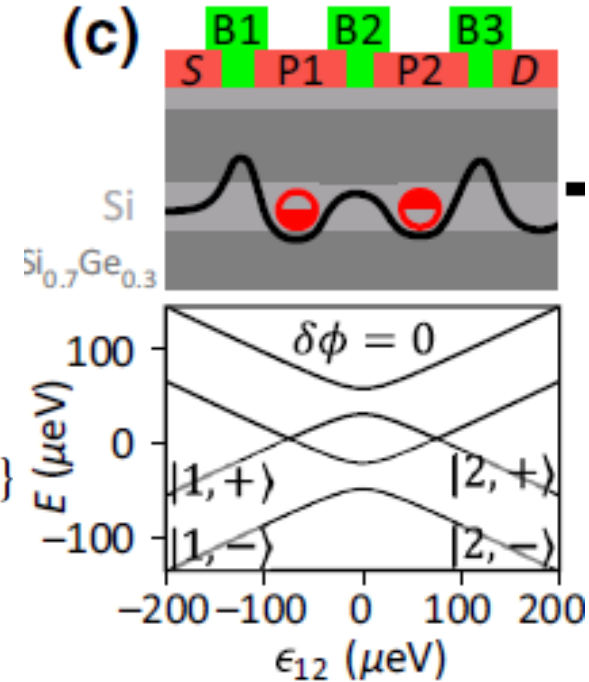
$$\{|i, +\rangle, |i, -\rangle, |j, +\rangle, |j, -\rangle\}$$

Intra-valley tunneling

$$t_{ij} = (1/2)t_c(1 + e^{-i\delta\phi_{ij}})$$

Inter-valley tunneling

$$t'_{ij} = (1/2)t_c(1 - e^{-i\delta\phi_{ij}})$$



Valley degree of freedom in silicon quantum dots

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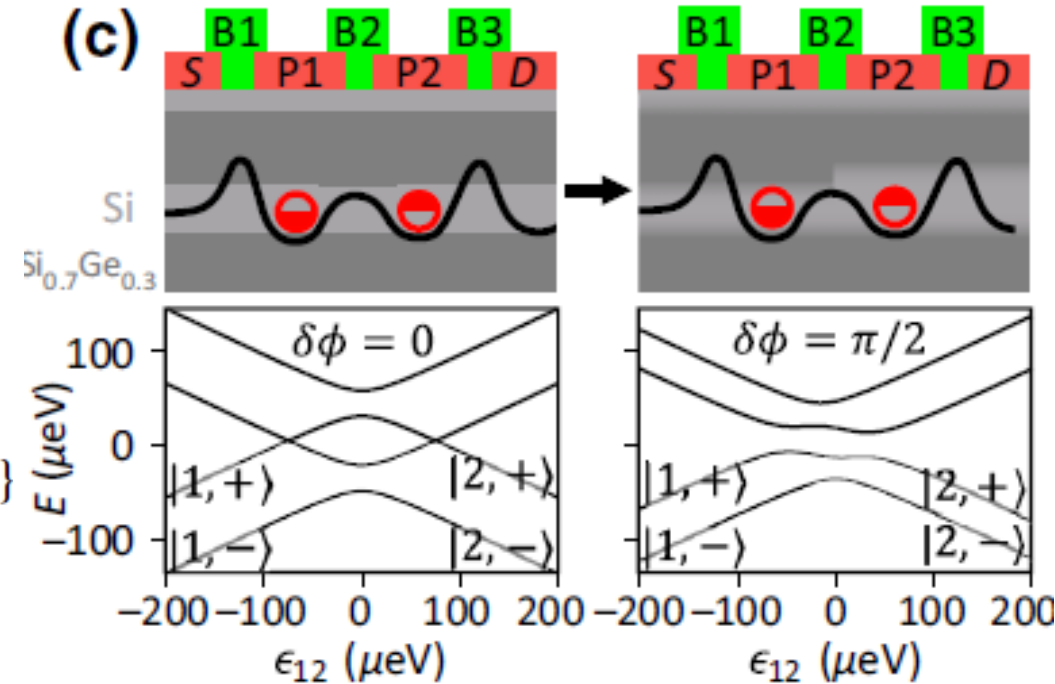
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 Inter-valley tunneling
 $t'_{ij} = (1/2)t_c(1 - e^{-i\delta\phi_{ij}})$

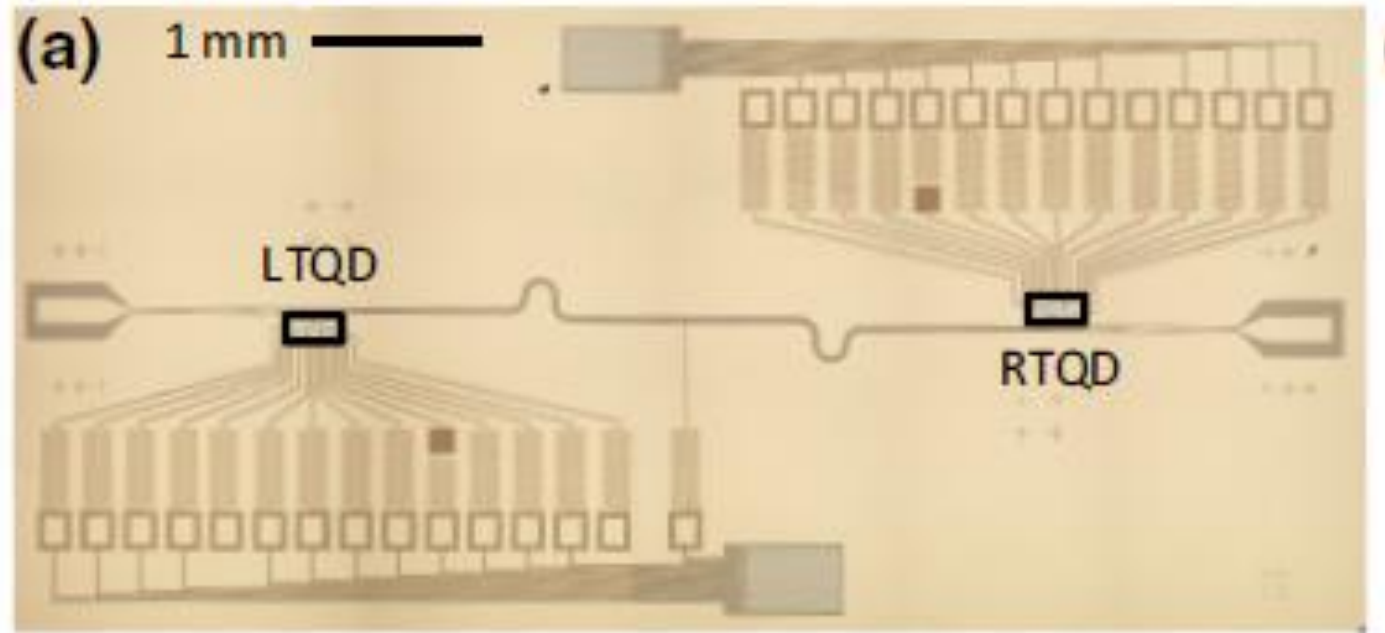
Valley phase difference, because of valley orbit coupling

$$\Delta = \Delta(x); \Delta_i \neq \Delta_j$$



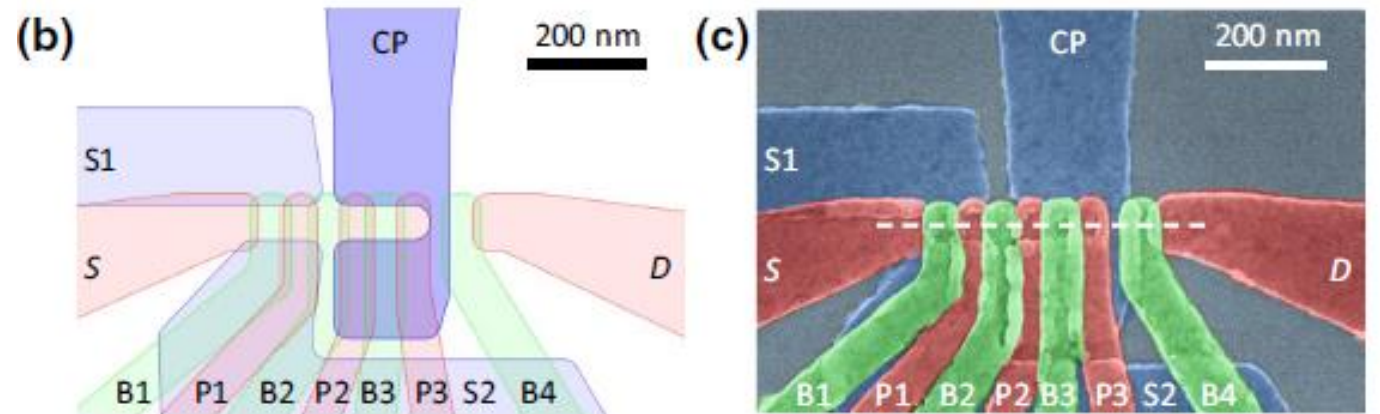
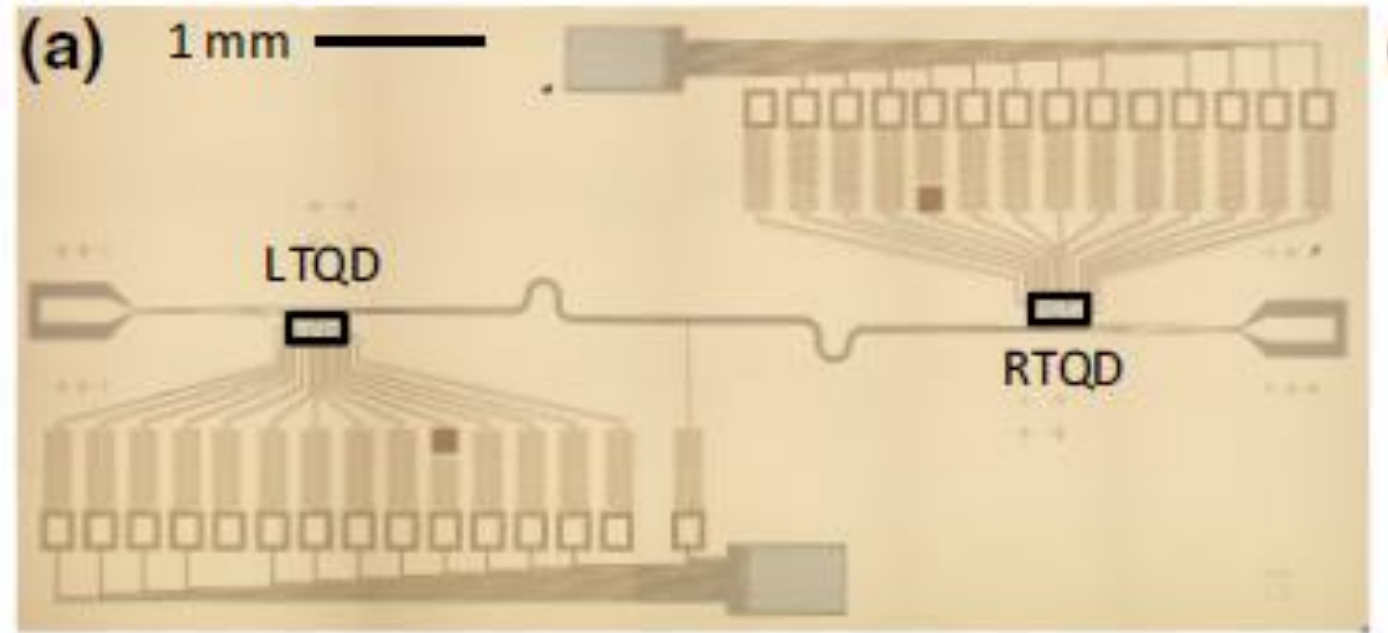
Experimental Setup

- Half wave CPW resonator coupled to TQD, $f_r = 6.76$ GHz
 $\kappa/2\pi = 1.5$ MHz



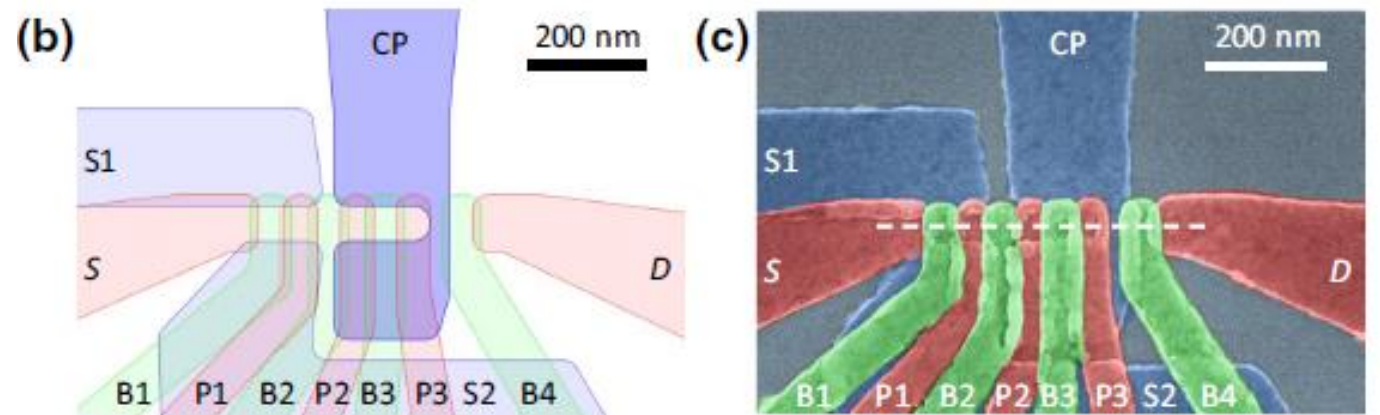
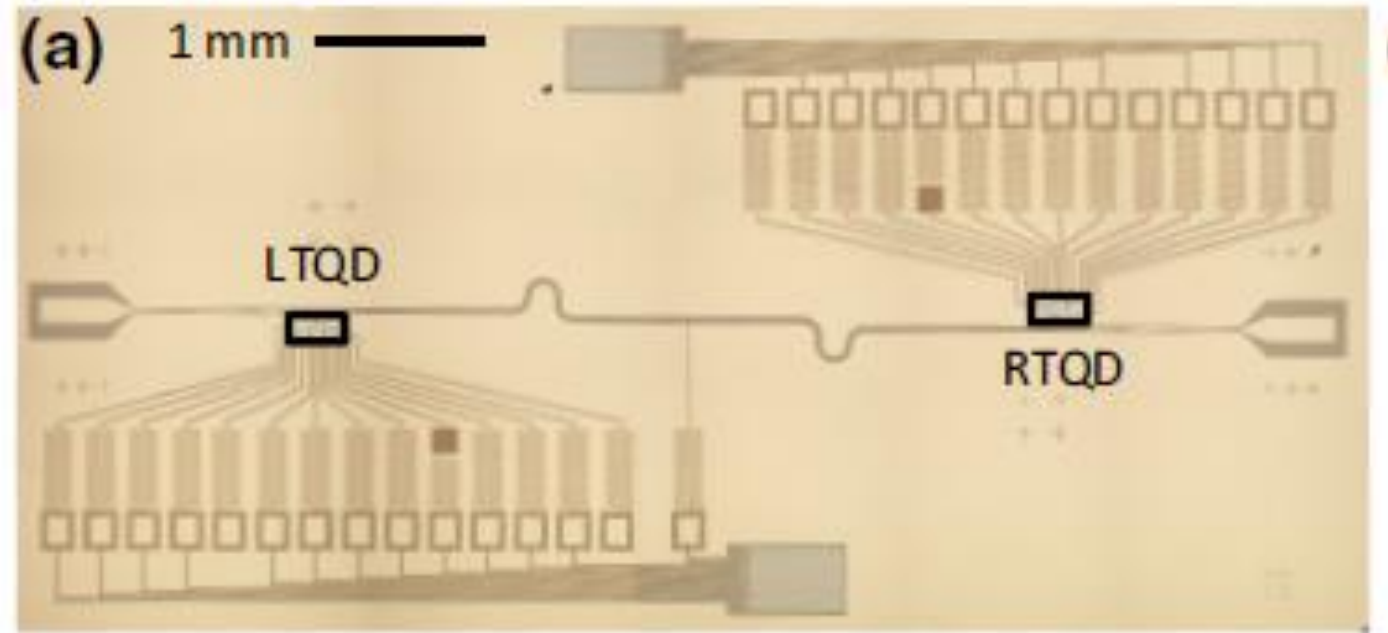
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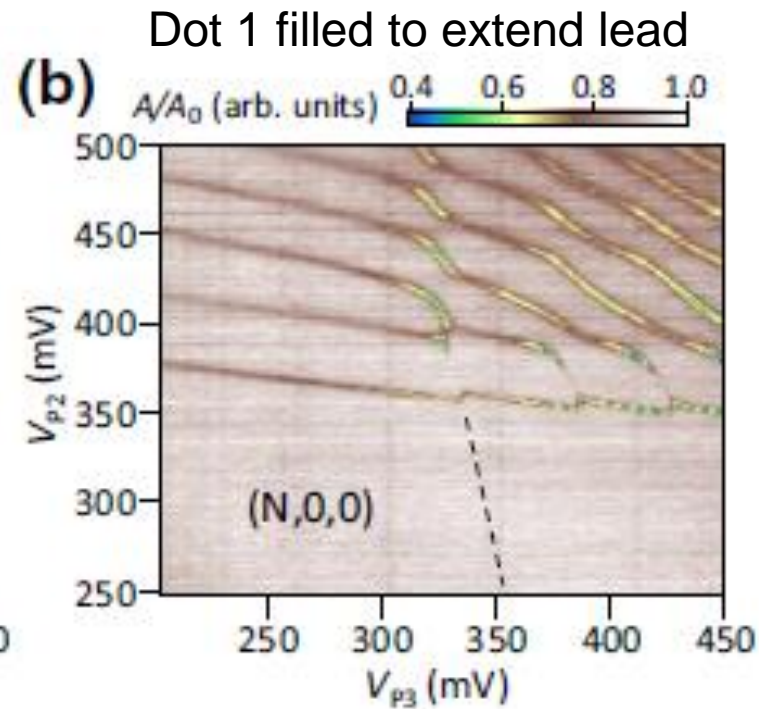
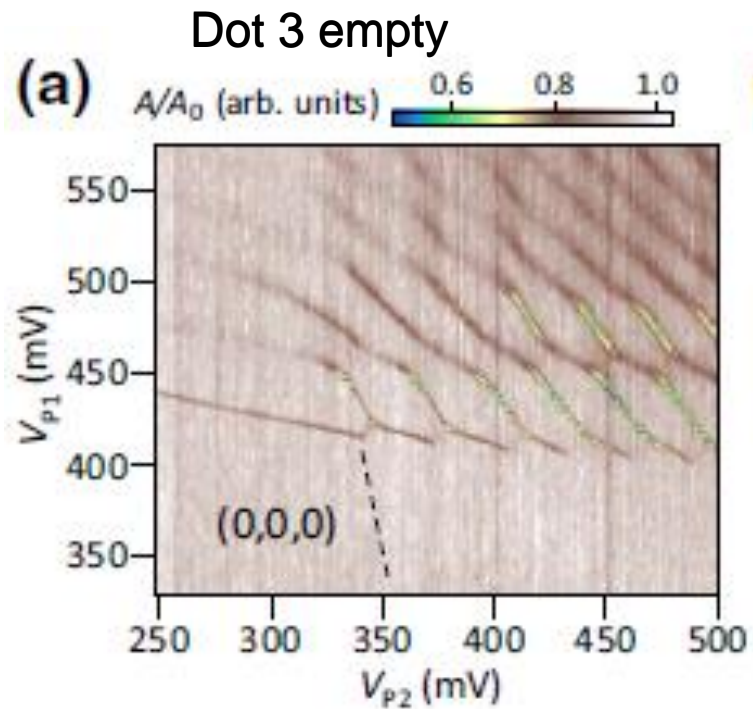
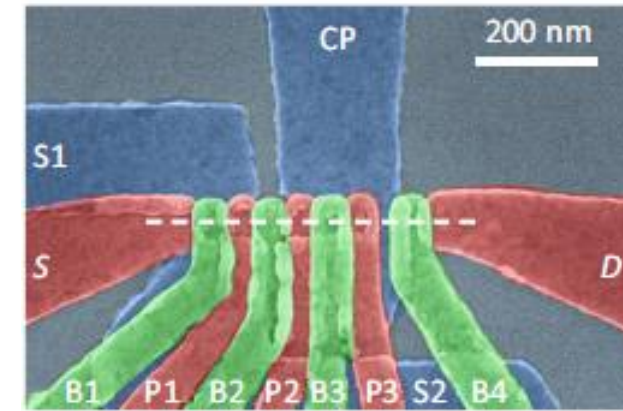
Experimental Setup

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- CP gate wraps around dot 3 to enhance dot-resonator coupling



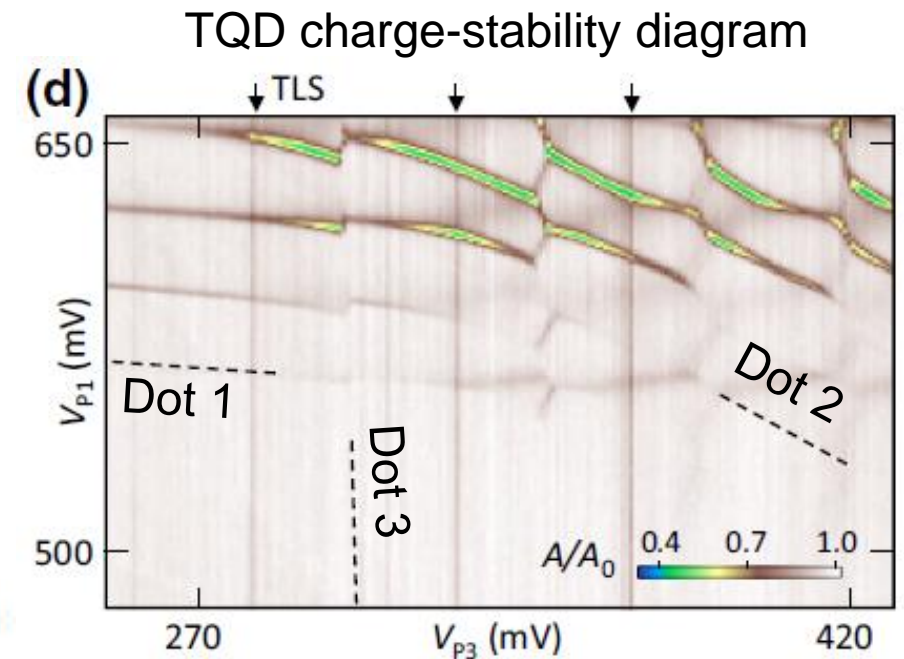
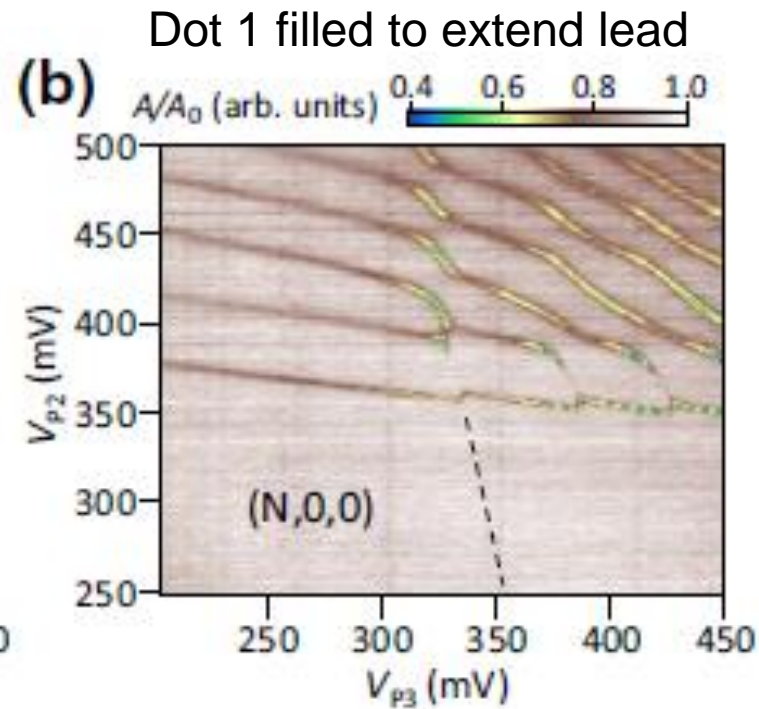
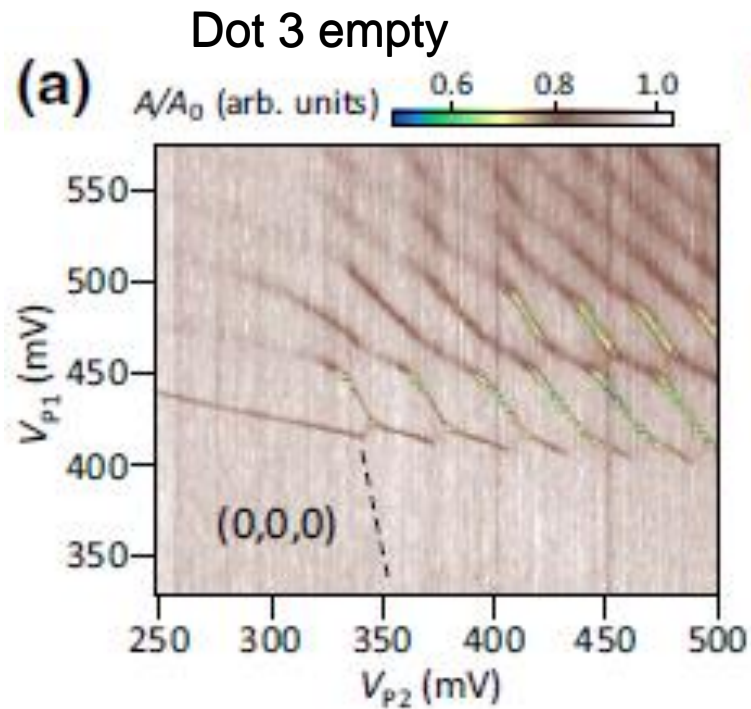
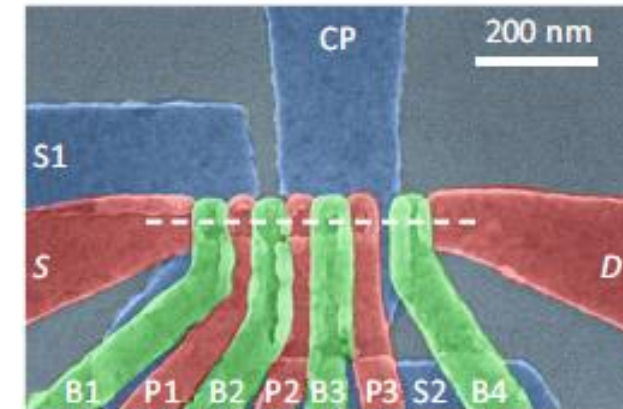
Tuning towards last electron in TQD

- Read-out of resonator that is sensitive to charge transitions



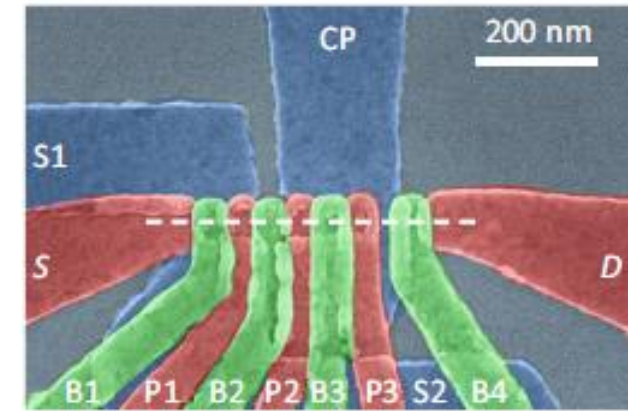
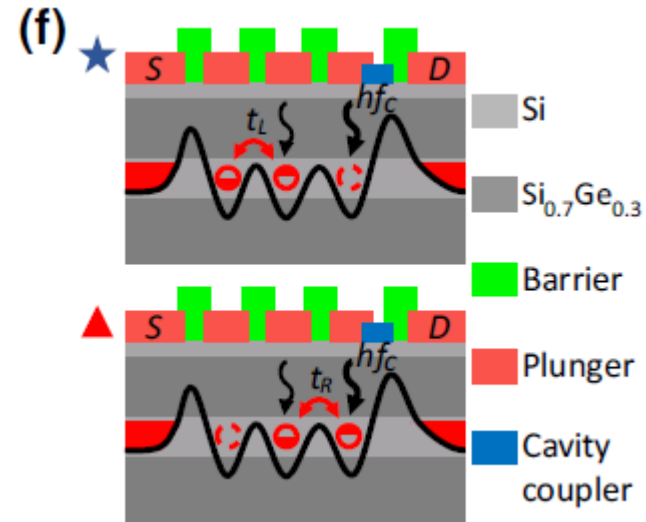
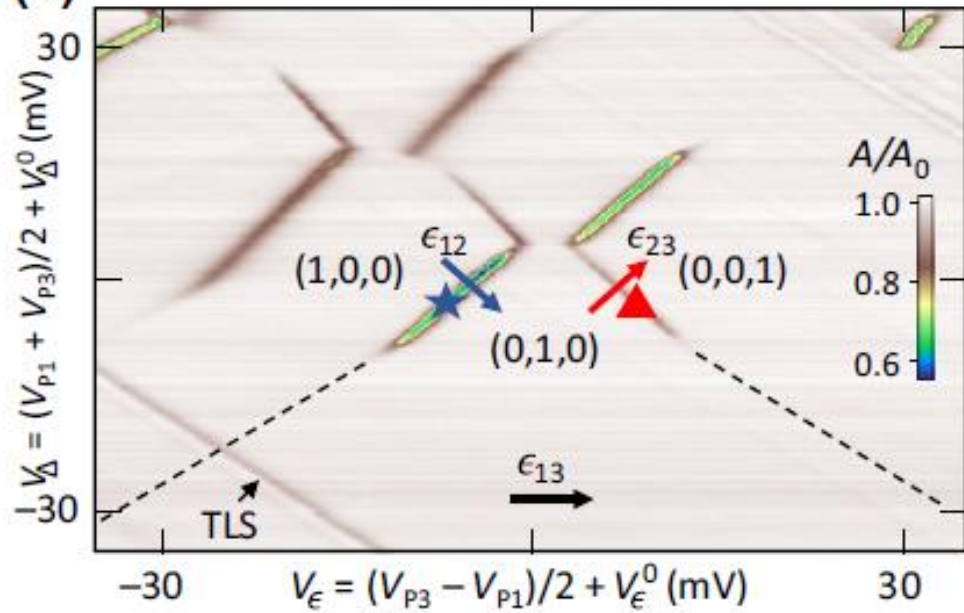
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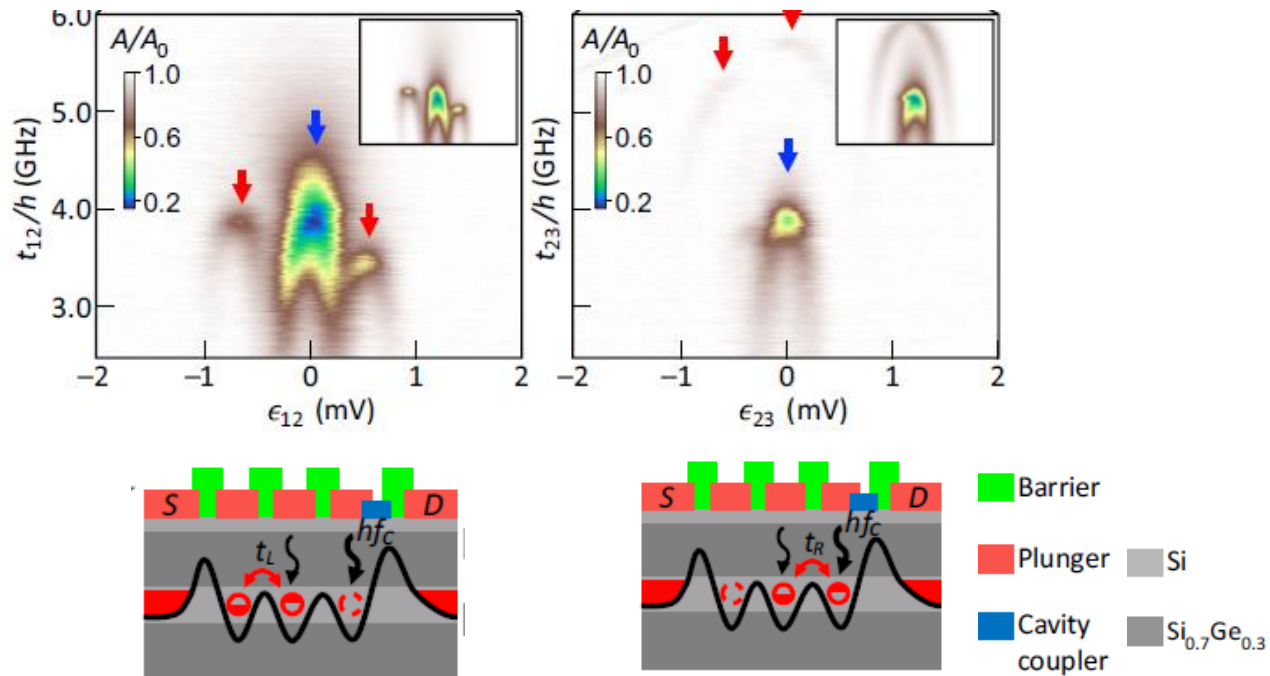
Operation at last electron in the TQD

(e) Operation point in transformed gate axes

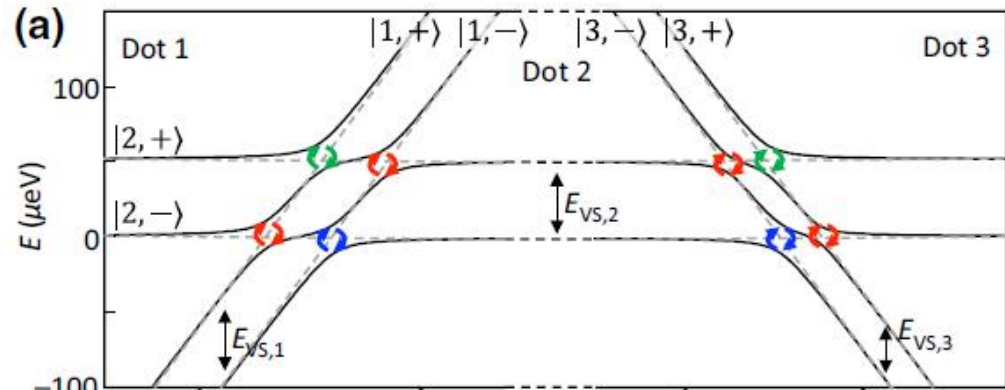


Spectroscopic measurement of the valley states

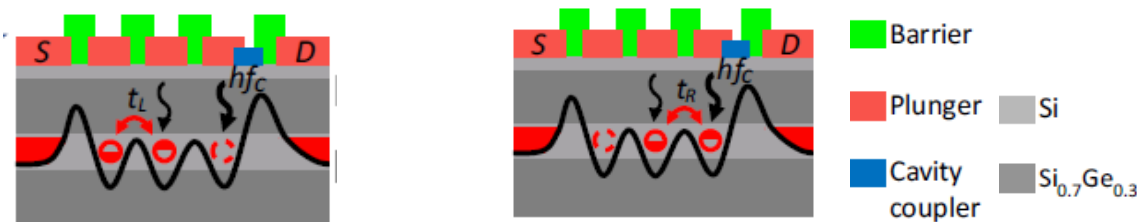
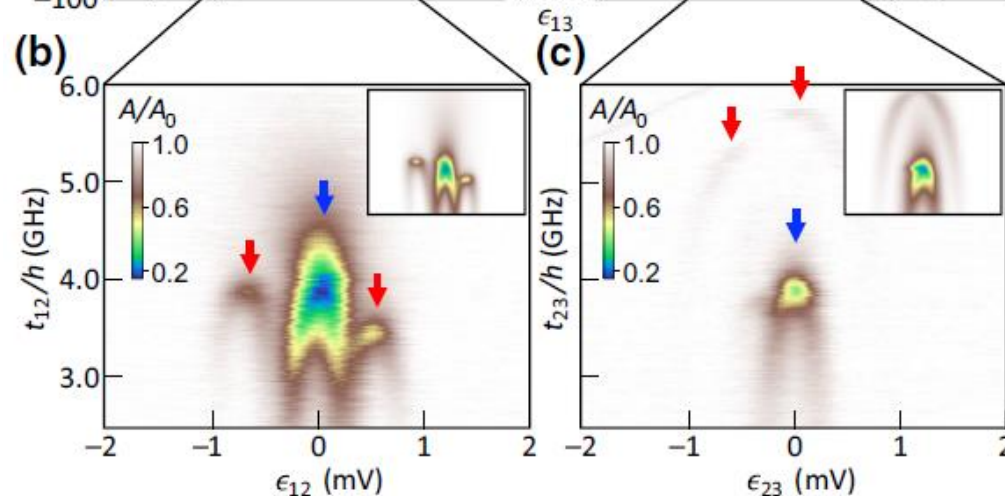
- Sweep barrier versus detuning



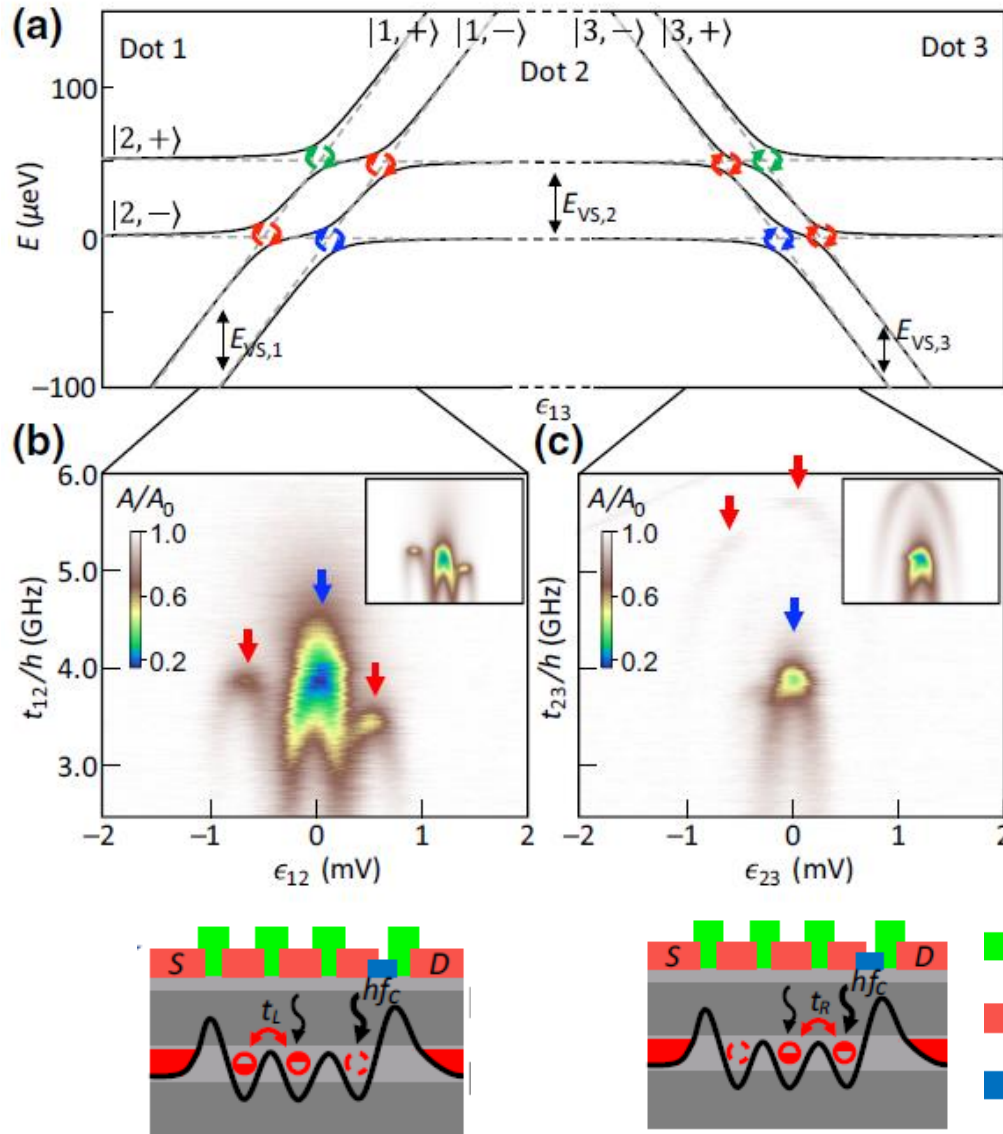
Spectroscopic measurement of the valley states



- Sweep barrier versus detuning
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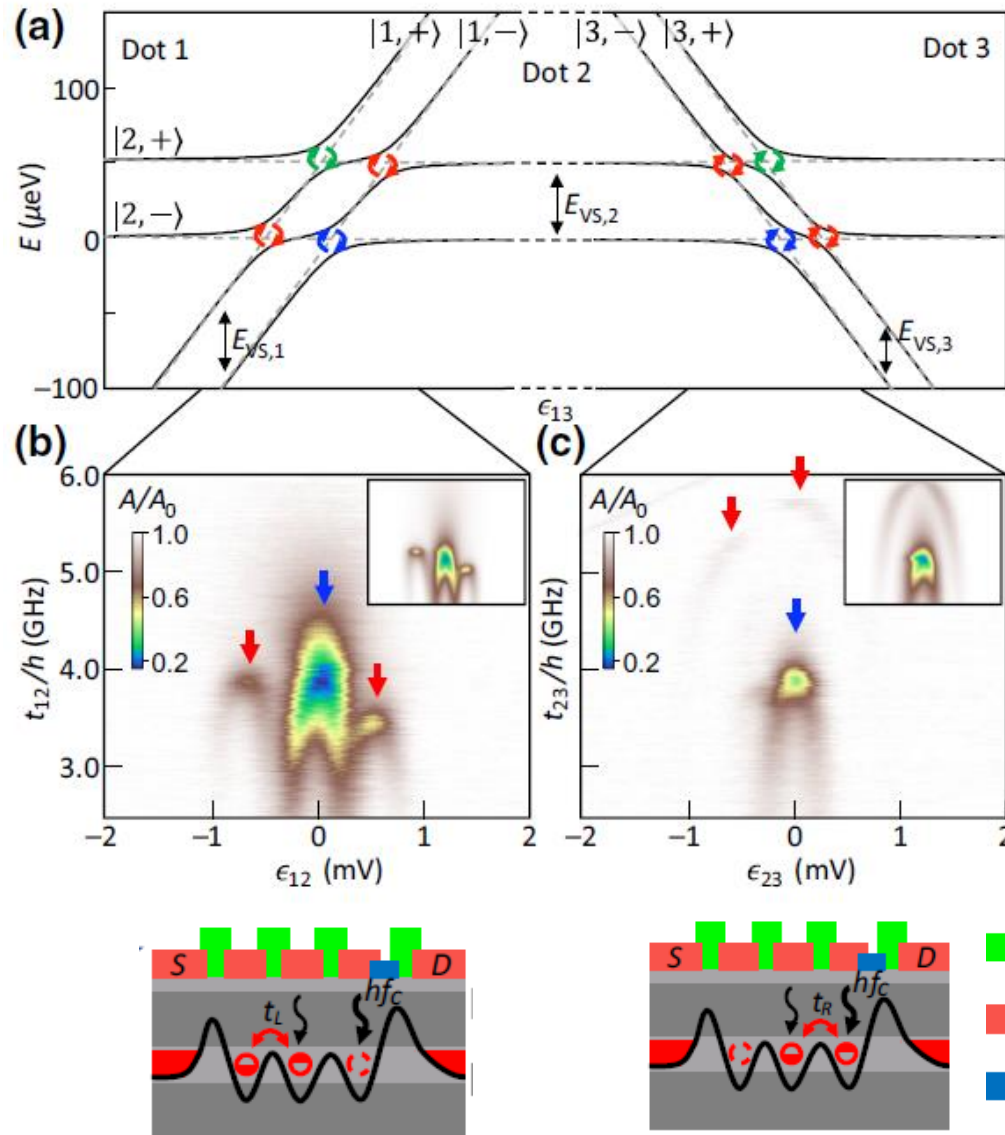


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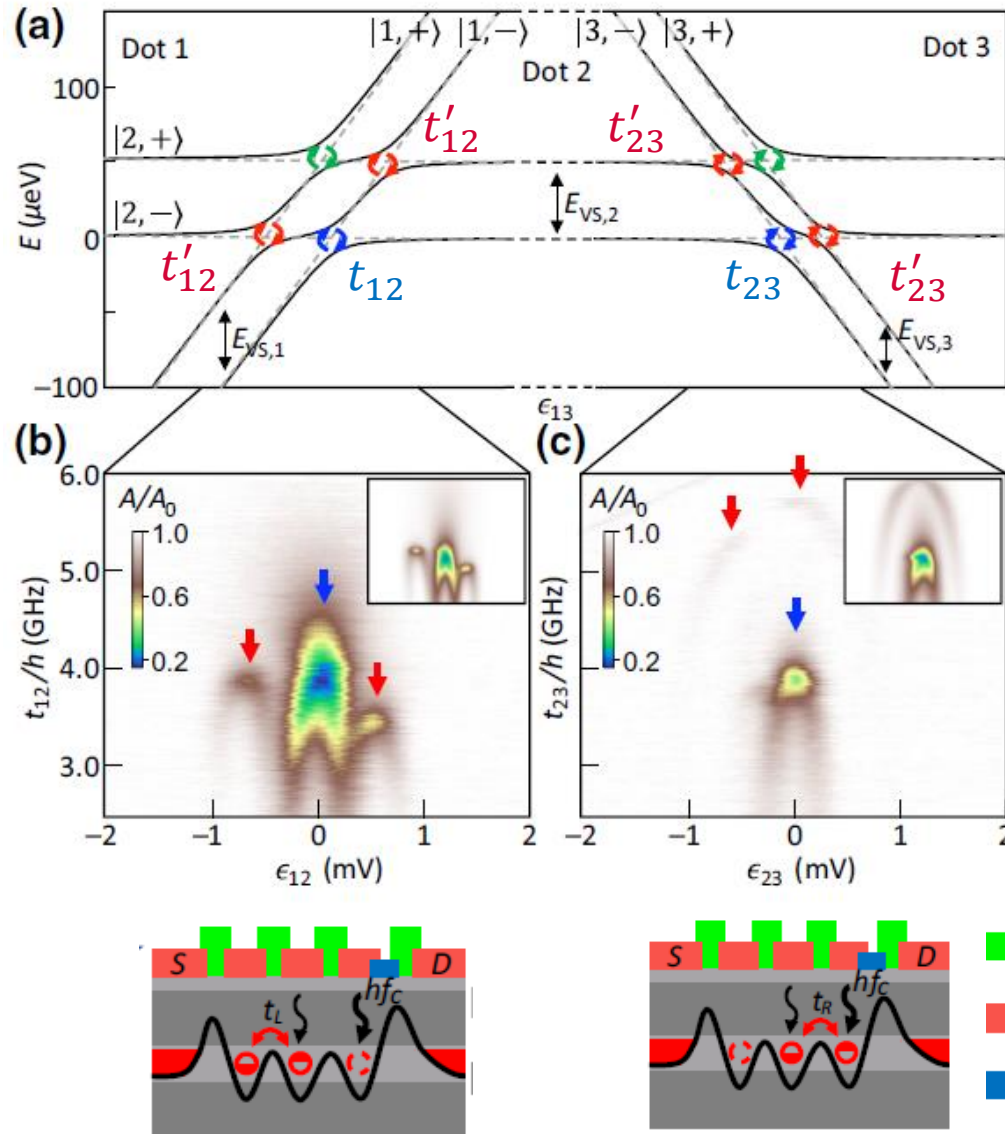
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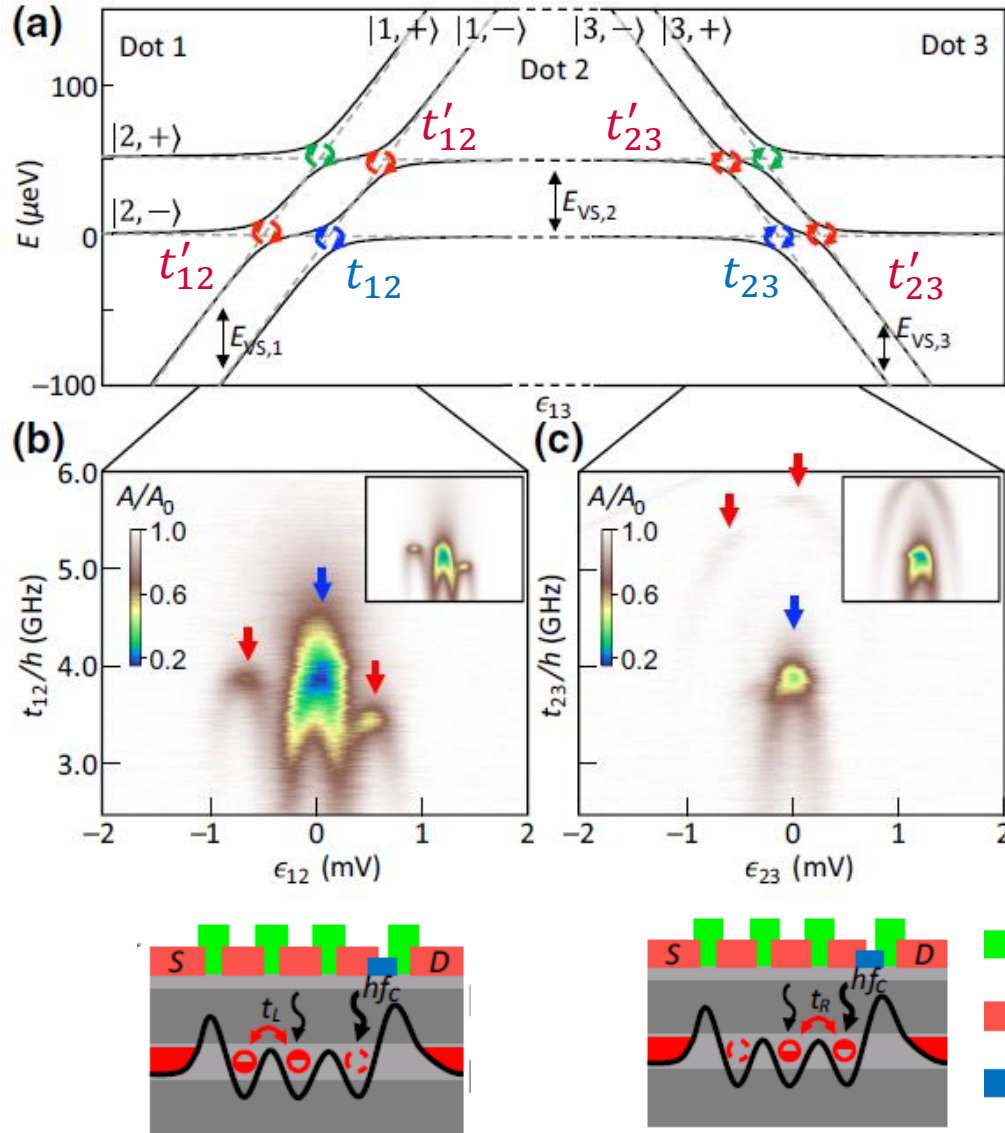
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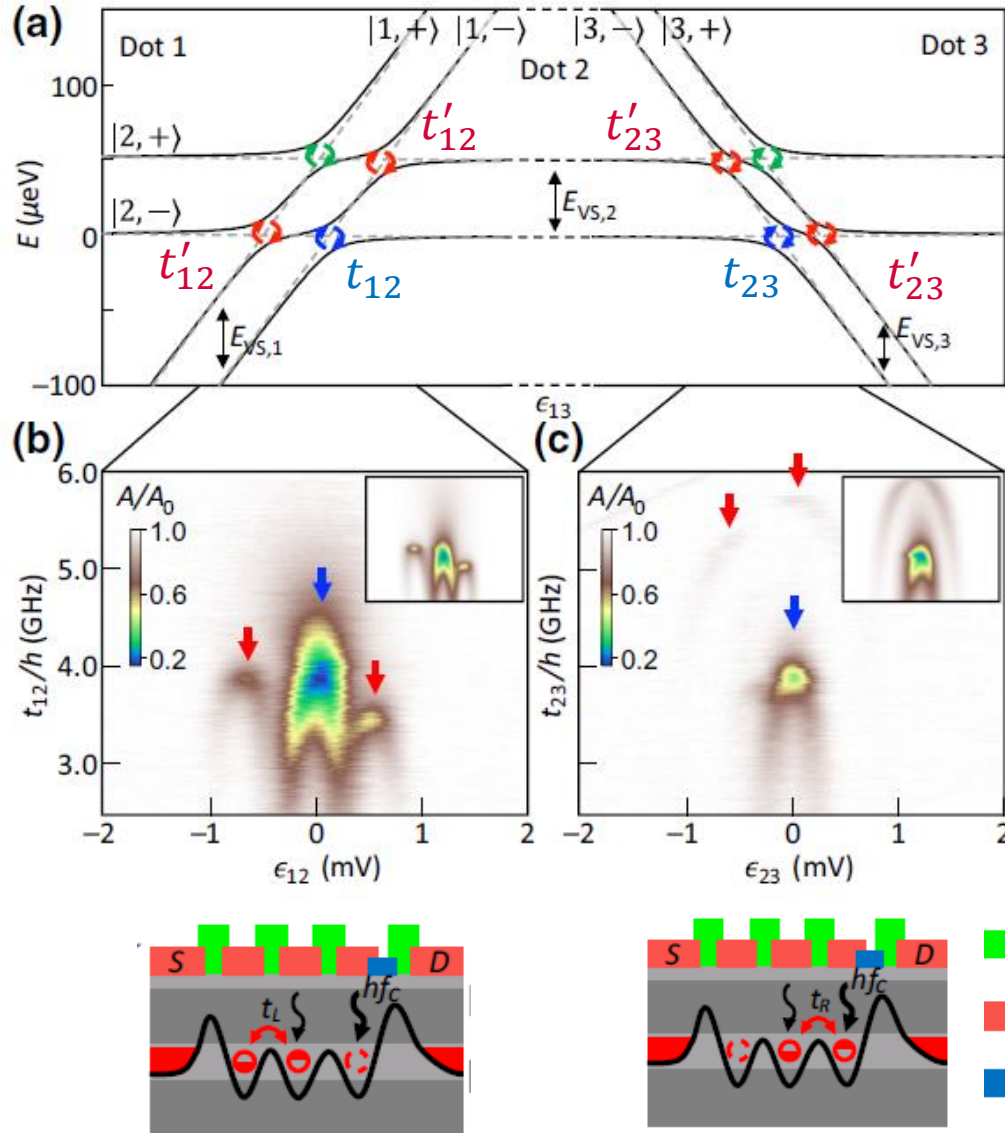
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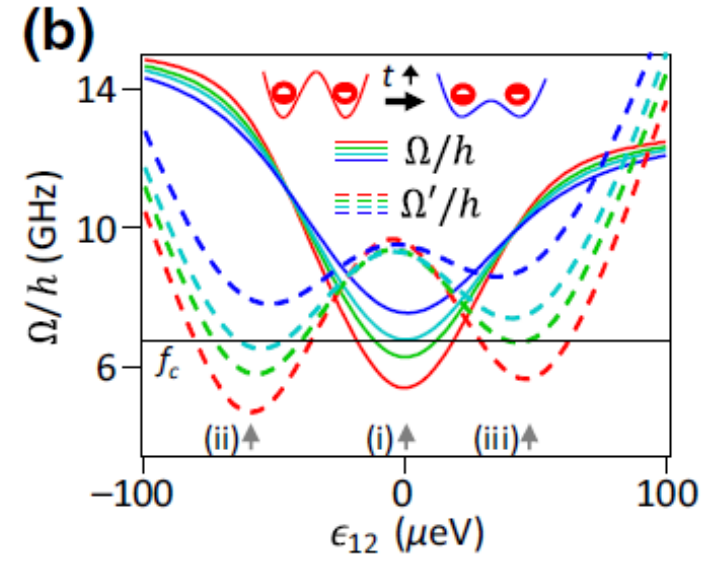
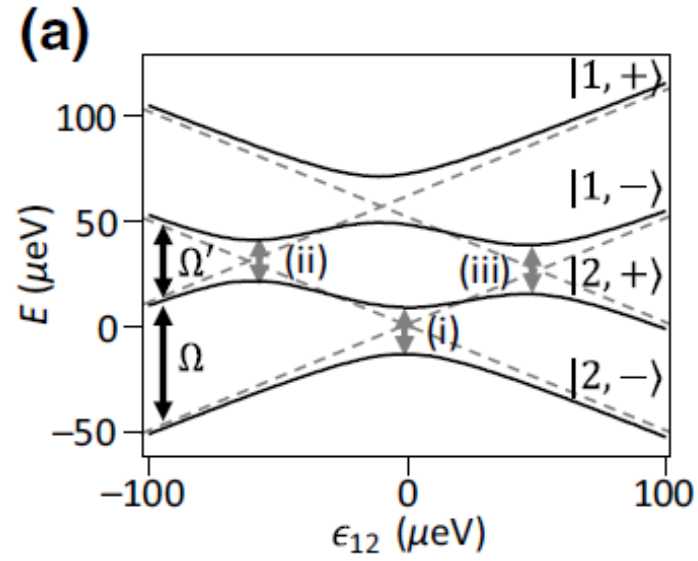
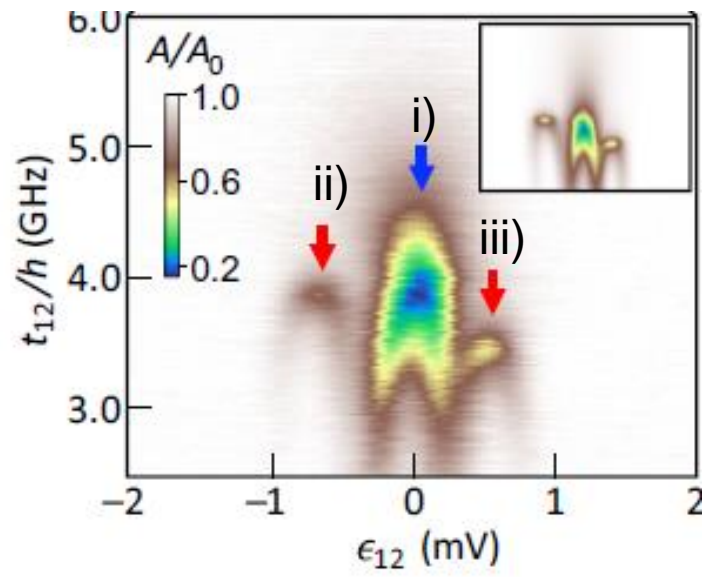
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Spectroscopic measurement of the valley states

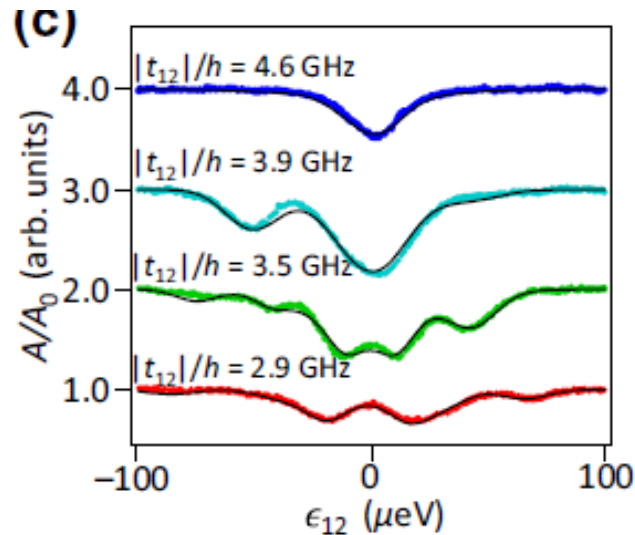
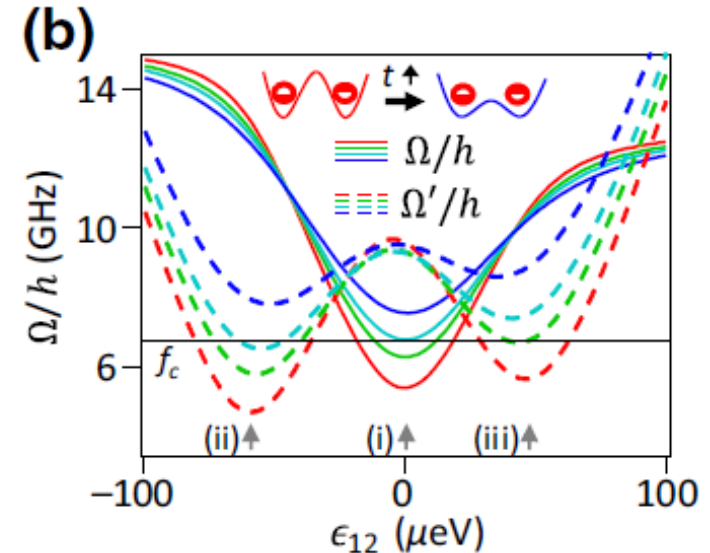
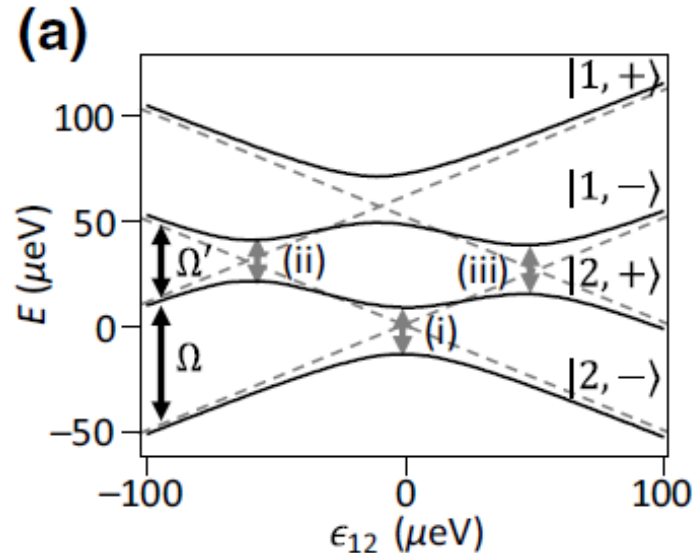
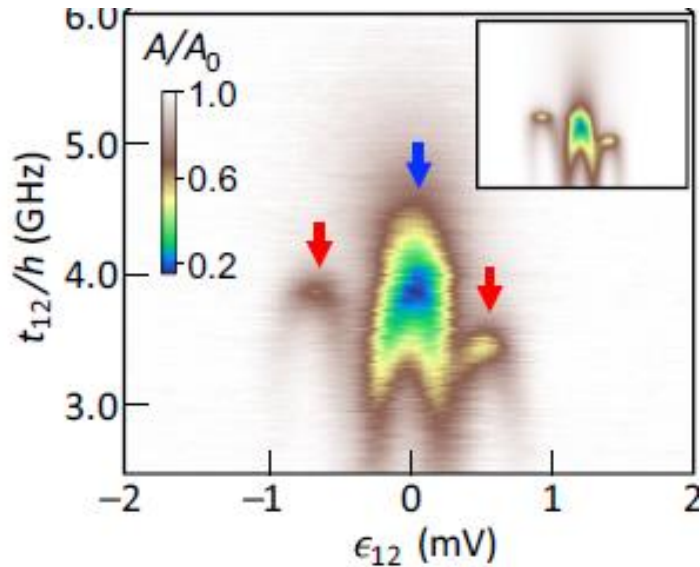


- Sweep barrier versus detuning
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- Operation temperature $T_e = 350$ mK enables sensing of higher lying transitions
- Intra and inter-valley crossings are detected
- Horizontal positioning of archs due to $E_{V,i}$
- Vertical spacing of archs suggests $t'_{ij} = t'_{ij}(\epsilon)$

Quantitative data analysis



Quantitative data analysis

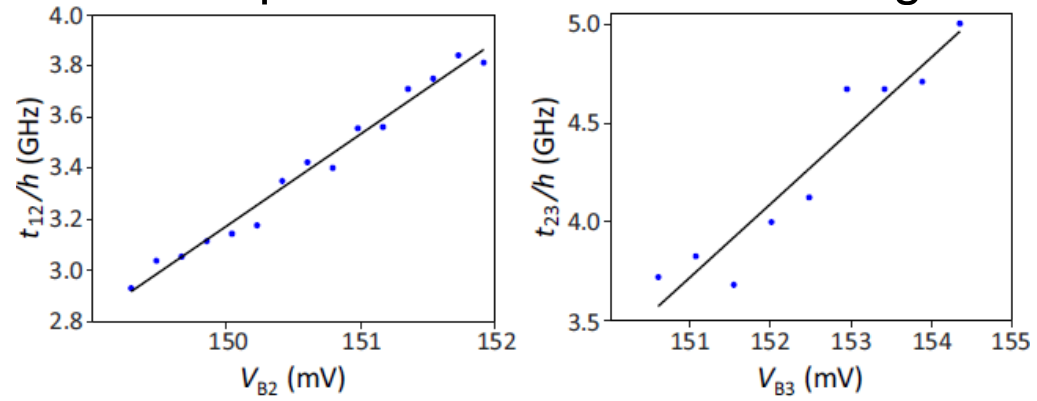


• Analysis of traces of fixed t_{12} (V_B)

- Numerical diagonalisation of Hamiltonian for each ϵ_{12}
- Feed resulting energies into cavity input-output theory
- Add linear dependence $t_{12} = t_{12}(\epsilon = 0) + a_{12}\epsilon_{12}$ to account for asymmetry
- Independently measure charge decoherence rate γ_{12}
- Fit parameters:
 - Valley splittings $E_{V,i}$ - Intra valley-tunnelings $t_{12}(\epsilon_{12} = 0)$
 - Valley phase differences $\delta\Phi_{12}$ - Asymmetry a_{12}
 - Lever arms α_{ij} - Charge-cavity coupling rate g_{12}
 - Inhomogeneous broadening σ_{12}

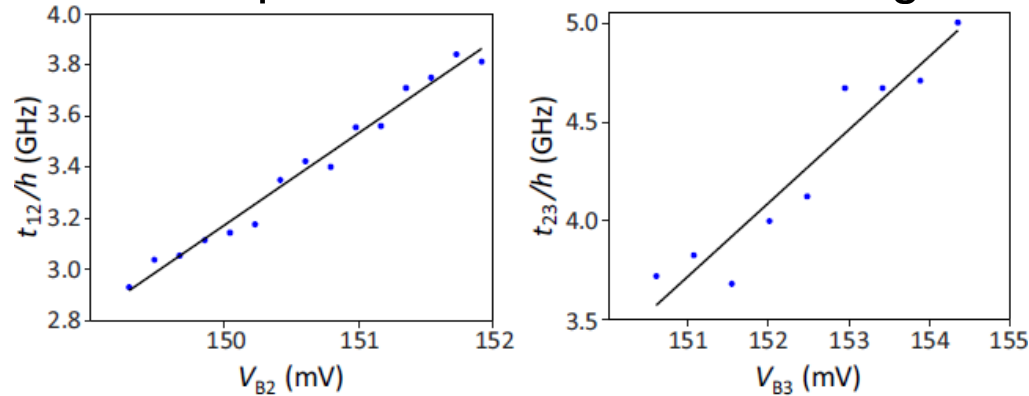
Results of data analysis

- Linear dependence between barrier gate and tunnel couplings



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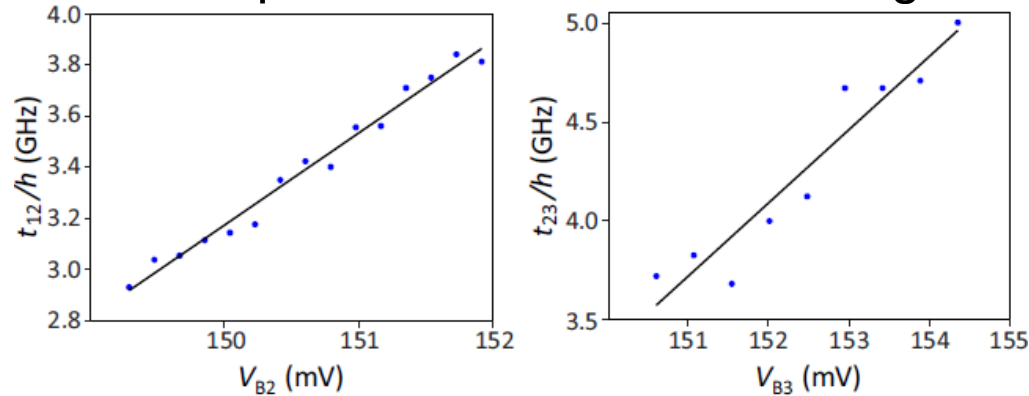


- Consistent extraction of valley splittings

$(1,0,0)$ - $(0,1,0)$: $E_{V1} = 63 \mu\text{eV}$, $E_{V2} = 53 \mu\text{eV}$; $(0,1,0)$ - $(0,0,1)$: $E_{V2} = 50 \mu\text{eV}$, $E_{V2} = 38 \mu\text{eV}$

Results of data analysis

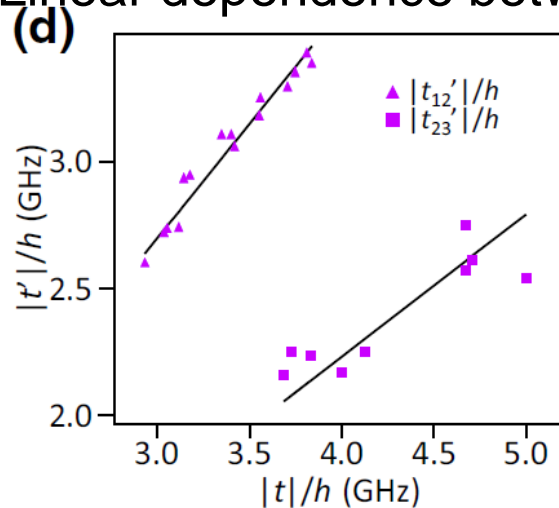
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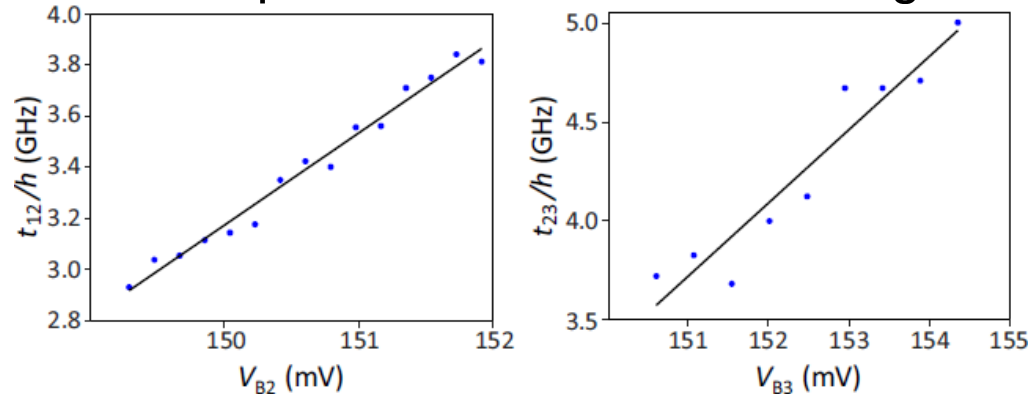
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- Linear dependence between intra- and intervalley coupling



Results of data analysis

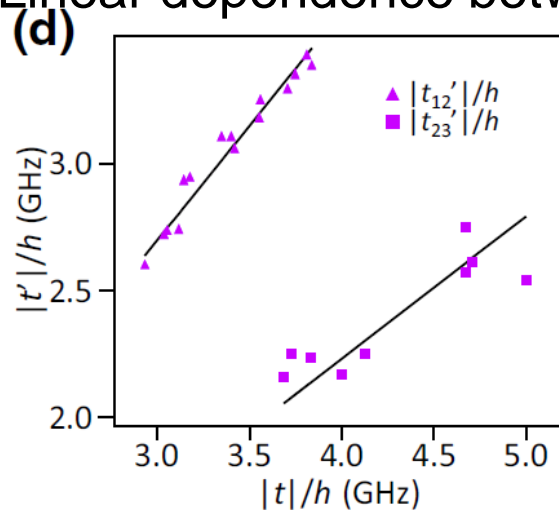
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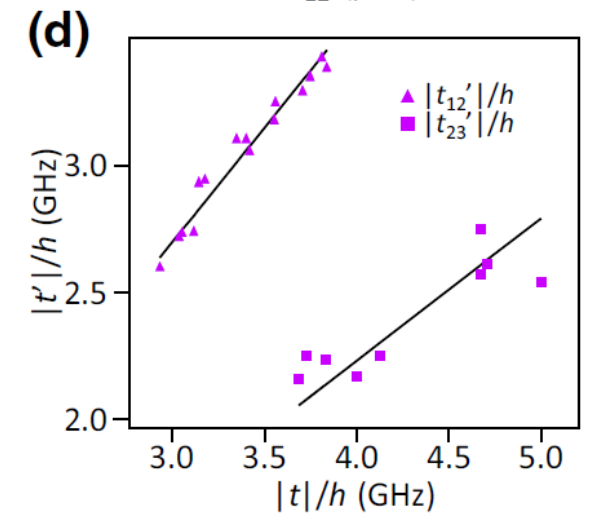
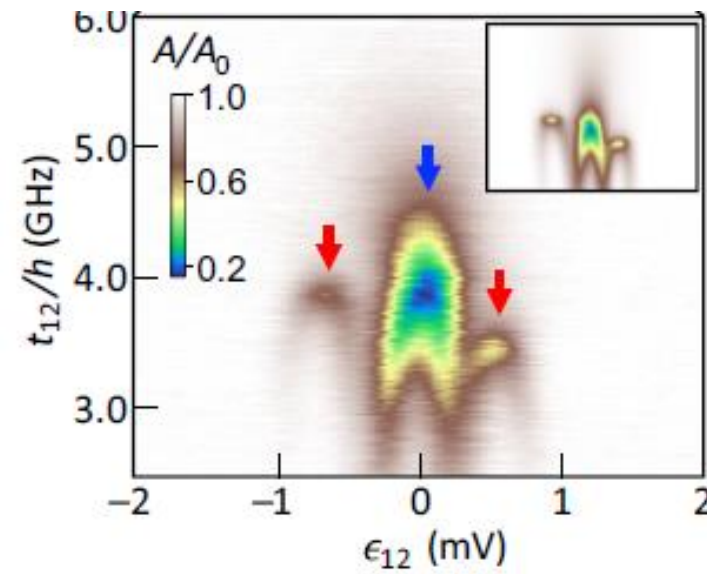
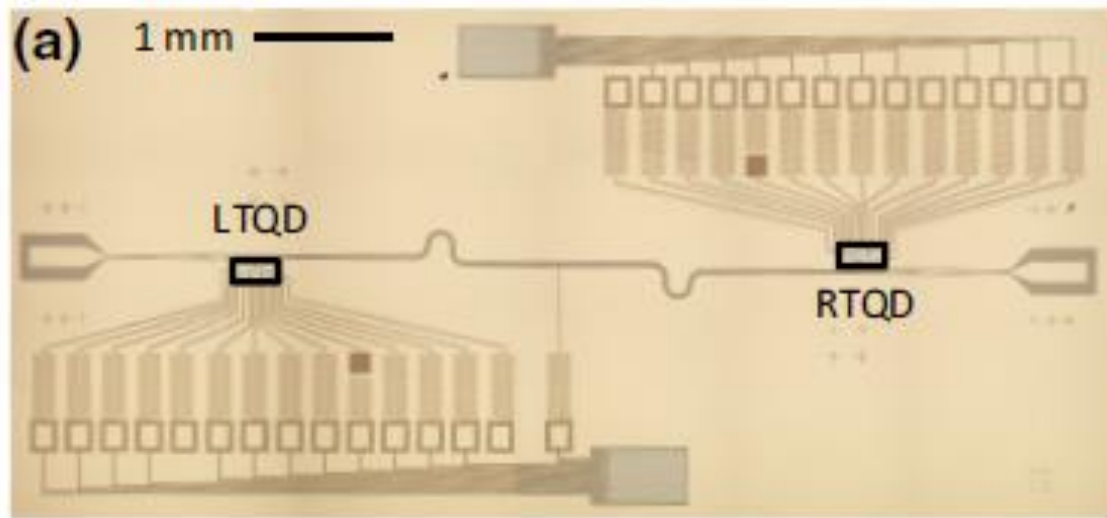
- Linear dependence between intra- and intervalley coupling



-> Large variations of valley phase $\delta\varphi_{ij} = 2 \arctan(|t_{ij}/t'_{ij}|)$ between different dots (length scale 200 nm)

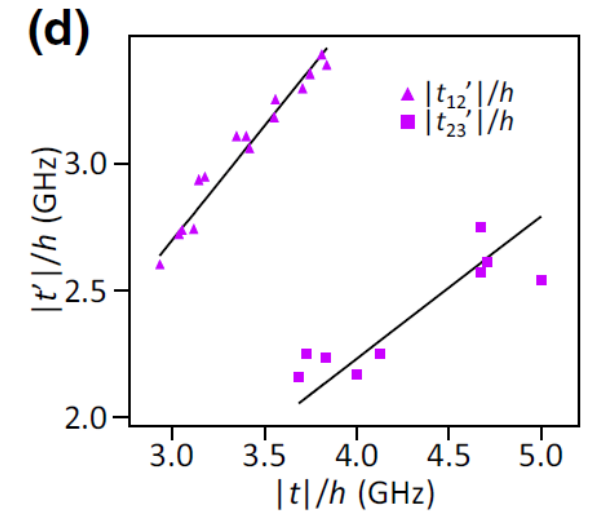
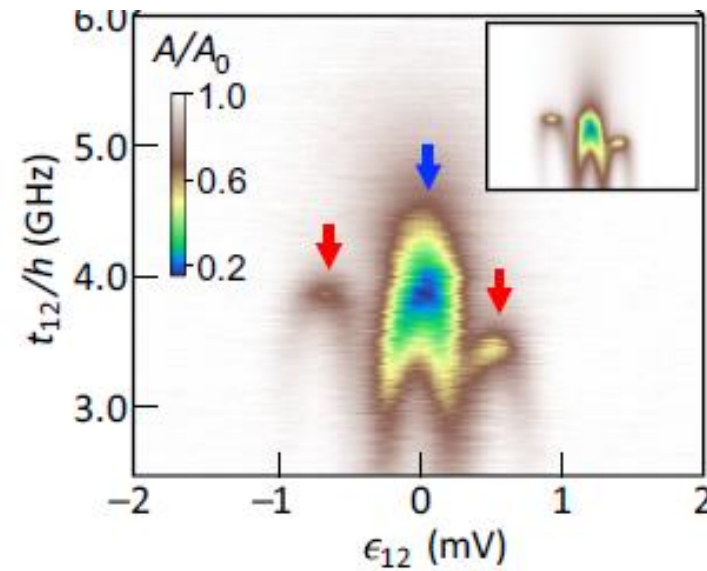
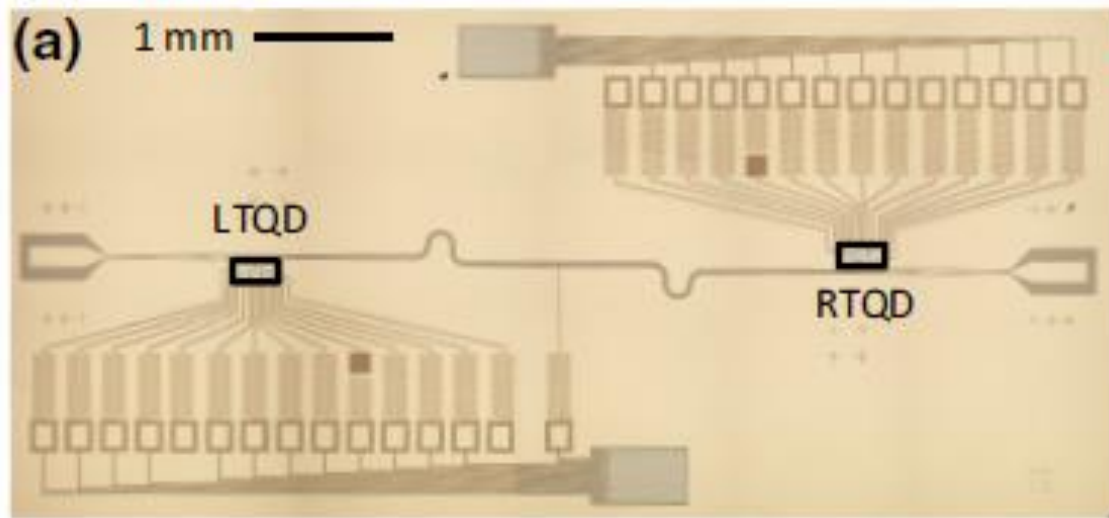
Summary

- Circuit QED as sensitive measure for curvature in quantum dot energy levels



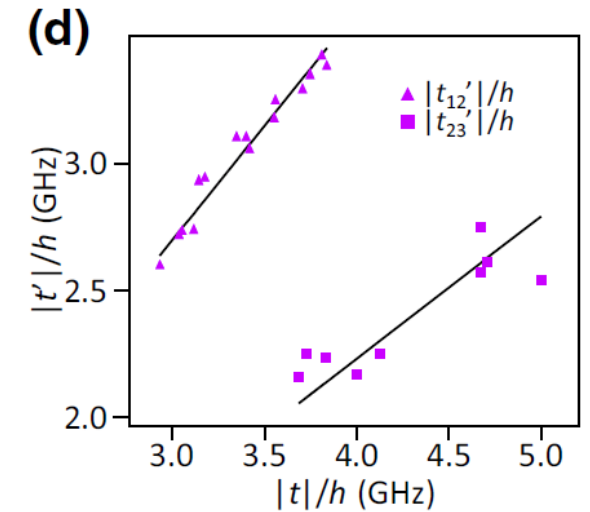
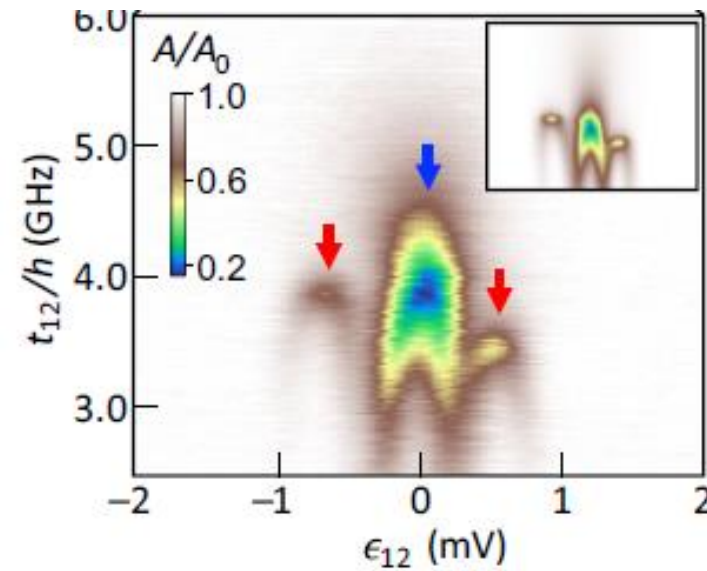
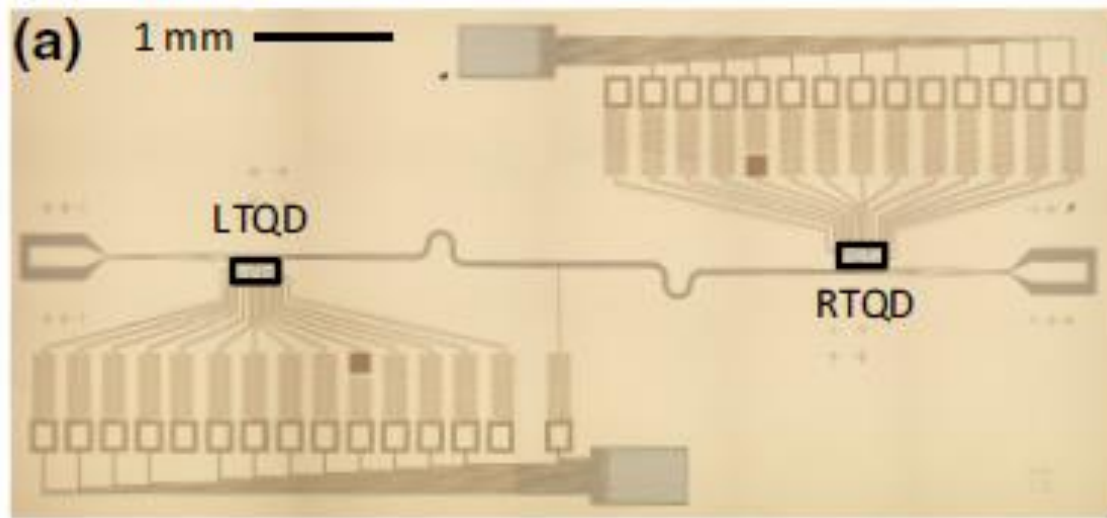
Summary

- Circuit QED as sensitive measure for curvature in quantum dot energy levels
- Spectroscopical measurement of valley-splittings



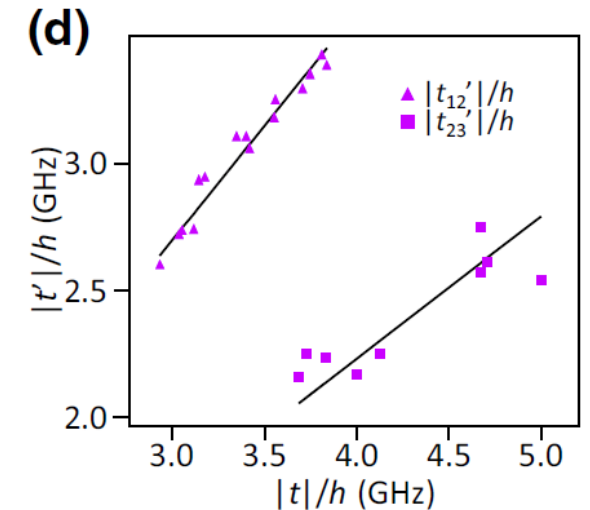
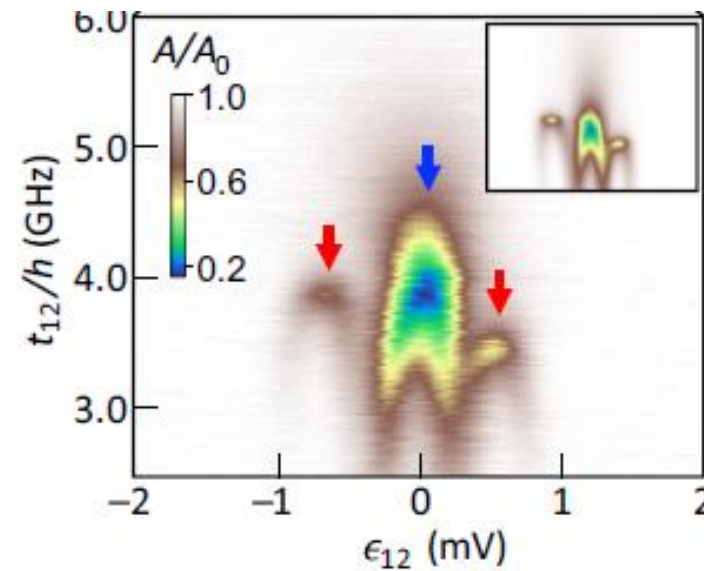
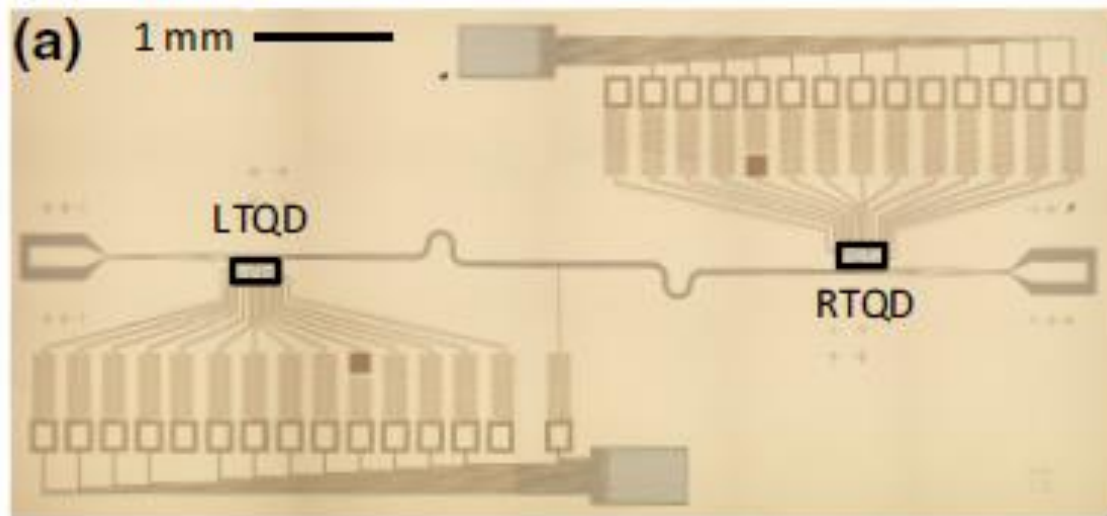
Summary

- Circuit QED as sensitive measure for curvature in quantum dot energy levels
- Spectroscopical measurement of valley-splittings
- Consistent with theory, inter- and intravalley splitting scale linearly



Summary

- Circuit QED as sensitive measure for curvature in quantum dot energy levels
- Spectroscopical measurement of valley-splittings
- Consistent with theory, inter- and intravalley splitting scale linearly
- Observation of significant variations of the valley phase difference over approximately 200 nm
 - Improvement of Si/SiGe interface is needed



Thank you
for your attention.